



3rd Workshop on Density Functional Theory (DFT2025):
Fundamentals, Developments, and Applications
RIKEN Kobe Campus
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Time Dependent Density Functional Theory for Extremely Nonlinear Optics

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Today I will talk on:

- Solve Maxwell and Schrödinger (time-dependent Kohn-Sham) equations simultaneously.
- Directly connecting electromagnetism and quantum mechanics.

Classical electromagnetic fields

$$\nabla \times \nabla \times \mathbf{A} + \frac{1}{c^2} \frac{\partial^2}{\partial t^2} \mathbf{A} = \frac{4\pi}{c} \mathbf{j}$$

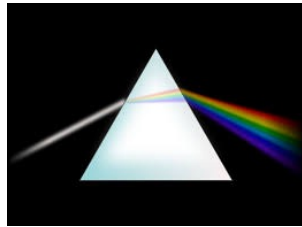
Quantum electronic motion

$$i\hbar \frac{\partial}{\partial t} \psi_i = \left\{ \frac{1}{2m} \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right)^2 + V_{ion} + V_H + V_{xc} \right\} \psi_i$$
$$\mathbf{j} = -\frac{e}{2m} \left\{ \psi_i^* \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right) \psi_i + c.c. \right\}$$

- Why and where it is necessary?  Extreme Optics
- How it is carried out?
- How it works?

**Light-matter interaction:
usually characterized by dielectric function/index of refraction**

$$n = \sqrt{\epsilon}$$

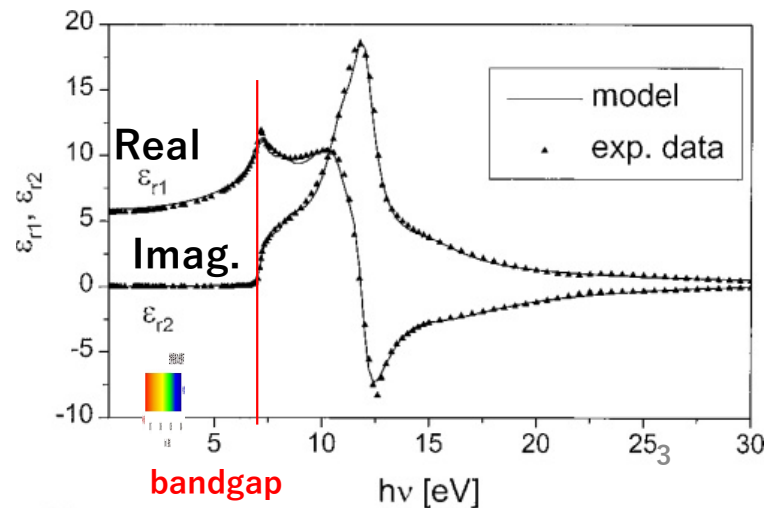


Dispersion
(freq. dep.) $n(\omega), \epsilon(\omega)$

Nonlinearity
(Intensity dep.) $n = n_0 + n_2 E^2$

Transparent dielectric
= real dielectric function/index of refraction
for visible frequencies (~ 1.5 - 3.0 eV)

Dielectric function of diamond

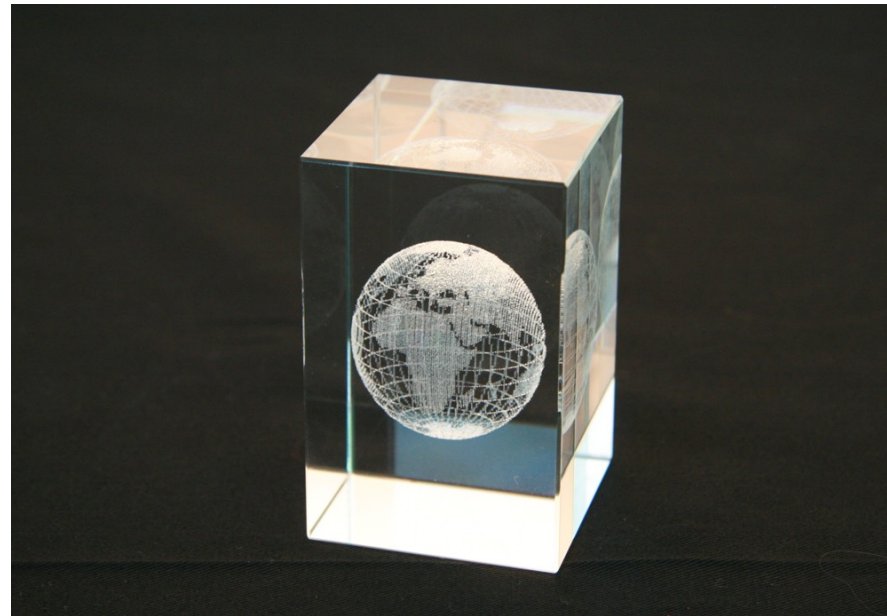


Dielectric function is not complete/sufficient for optics!

Glass becomes absorptive for very strong light: Laser processing

$$\begin{array}{ccc} \text{Im } \varepsilon = 0 & \xrightarrow{\text{blue arrow}} & \text{Im } \varepsilon \neq 0 \\ \text{Transparent} & & \text{Absorptive} \end{array} \quad \text{Nonlinearity}$$

Such process cannot be described within ordinary electromagnetism.



Optics: Two aspects of light-Matter interaction

Light propagation (Maxwell's)eq.

$$\begin{aligned}\nabla \cdot \mathbf{B} &= 0 \\ \nabla \times \mathbf{E} + \frac{\partial \mathbf{B}}{\partial t} &= 0 \\ \nabla \cdot \mathbf{D} &= \rho \\ \nabla \times \mathbf{H} - \frac{\partial \mathbf{D}}{\partial t} &= \mathbf{j}\end{aligned}$$

e.g, FDTD (Finite-difference
time-domain method)

First-principles quantum mechanics calculations of optical constants

$$\epsilon_r = 1 + \frac{2Ne^2}{\epsilon_0 \hbar} \sum_j \frac{\omega_{j0} |\langle 0 | x | j \rangle|^2}{\omega_{j0}^2 - (\omega + i\gamma)^2}$$

e.g, GW-BS, TDDFT

Constitutive relation

$$\begin{aligned}\mathbf{D}(\mathbf{r}, t) &= \int_{-\infty}^t dt' \epsilon(t - t') \mathbf{E}(\mathbf{r}, t') \\ \mathbf{D}(\mathbf{r}, \omega) &= \epsilon(\omega) \mathbf{E}(\mathbf{r}, \omega)\end{aligned}$$

Electromagnetism (EM)

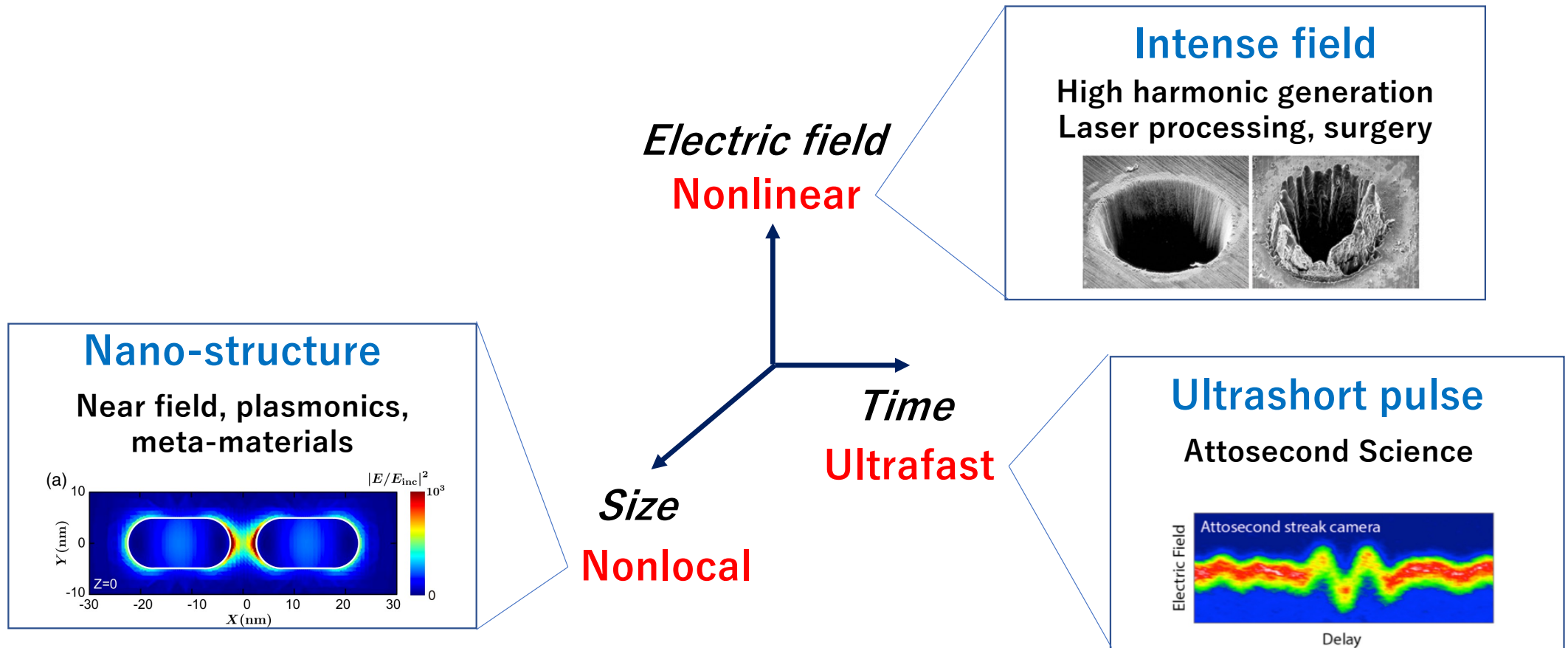
Quantum Mechanics (QM)

- EM and QM are separated using constitutive relation.
- Usually, **linear** and **local** constitutive relation is assumed.

$$\mathbf{D} = \epsilon \mathbf{E} + 4\pi \mathbf{P} \quad \mathbf{P}(\mathbf{r}, t) = \int_{-\infty}^t dt' \chi(t - t') \mathbf{E}(\mathbf{r}, t')$$

Extreme Optics

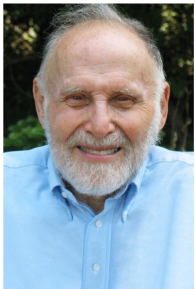
In frontiers of optical science using extreme pulsed light



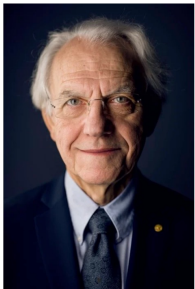
Recent Nobel prizes in related fields

Strong Light: Nonlinearity

The Nobel Prize in Physics 2018



© Arthur Ashkin
Arthur Ashkin
Prize share: 1/2



© Nobel Media AB. Photo: A. Mahmoud
Gérard Mourou
Prize share: 1/4



© Nobel Media AB. Photo: A. Mahmoud
Donna Strickland
Prize share: 1/4

“For their method of generating **high-intensity, ultra-short optical pulses**” (Mourou, Strickland)

Short-pulse: Ultrafast

The Nobel Prize in Physics 2023



Ill. Niklas Elmehed © Nobel Prize Outreach
Pierre Agostini
Prize share: 1/3



Ill. Niklas Elmehed © Nobel Prize Outreach
Ferenc Krausz
Prize share: 1/3



Ill. Niklas Elmehed © Nobel Prize Outreach
Anne L'Huillier
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“For experimental methods that generate **attosecond pulses of light** for the study of **electron dynamics in matter**”

Nano: Nonlocality

The Nobel Prize in Chemistry 2023



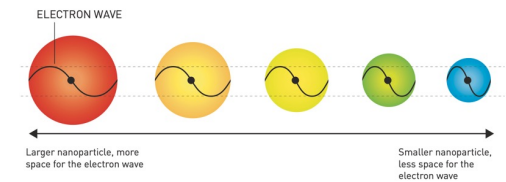
Ill. Niklas Elmehed © Nobel Prize Outreach
Moungi G. Bawendi
Prize share: 1/3



Ill. Niklas Elmehed © Nobel Prize Outreach
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Aleksey Yekimov
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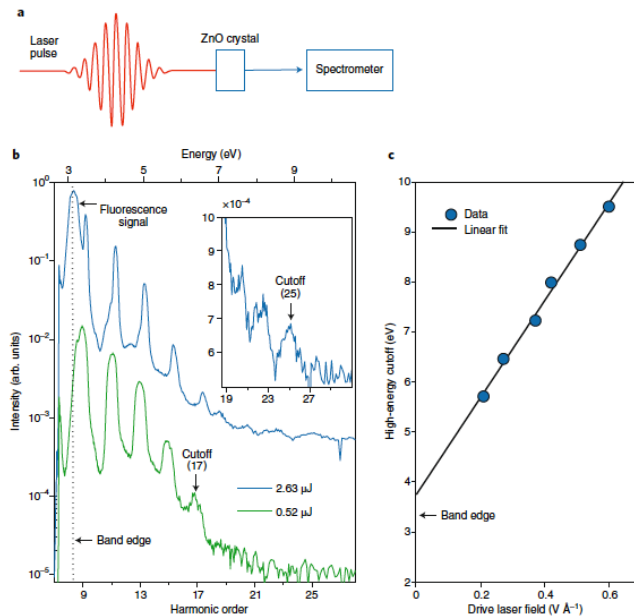


They planted an important seed for nanotechnology

<https://www.nobelprize.org/prizes/>

Nonlinearity: strong laser pulse on materials

High harmonic generation from solids



S. Ghimire et al, Nat. Phys. 7, 138 (2011)
S. Ghimire, D.A. Reis, Nature Physics 15, 10 (2019)

$$P(\mathbf{r}, t) = \int dt' \chi^{(1)}(t - t') E(\mathbf{r}, t')$$



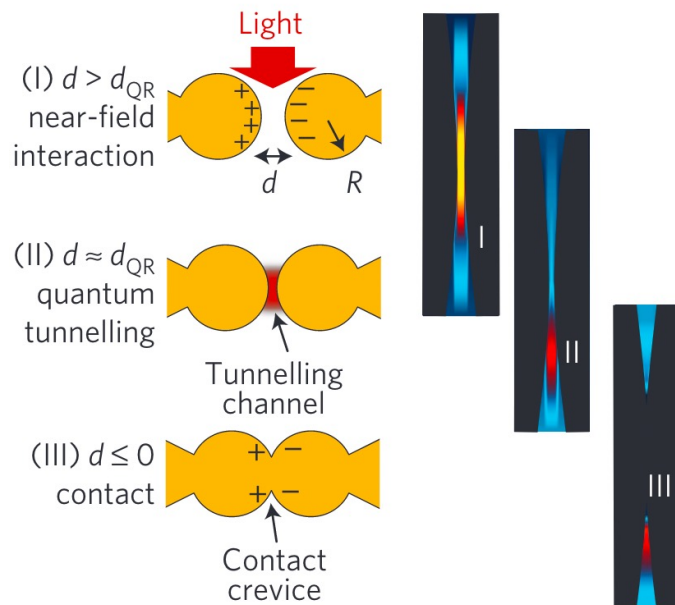
$$P(\mathbf{r}, t) = \int dt' \chi^{(1)}(t - t') E(\mathbf{r}, t') + \int dt' dt'' \chi^{(2)}(t - t', t - t'') E(\mathbf{r}, t') E(\mathbf{r}, t'') \\ + \int dt' dt'' dt''' \chi^{(3)}(t - t', t - t'', t - t''') E(\mathbf{r}, t') E(\mathbf{r}, t'') E(\mathbf{r}, t''') + \dots$$

Spatially local, but highly nonlinear

Explicit construction of nonlinear susceptibilities is difficult and useless.

Nonlocality: optical response in nano-material

Quantum Tunneling in Plasmonics



M.S. Tame et.al, Nature Phys. 9, 329 (2013)

$$P(\mathbf{r}, t) = \int dt' \chi^{(1)}(t - t') E(\mathbf{r}, t')$$



$$P(\mathbf{r}, t) = \int dt' \int d\mathbf{r}' \chi^{(1)}(\mathbf{r}, \mathbf{r}', t - t') E(\mathbf{r}', t')$$

Linear, but spatially nonlocal

Explicit construction of nonlocal susceptibility is difficult and useless.

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- Directly connecting electromagnetism and quantum mechanics.

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Quantum electronic motion

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$$\mathbf{j} = -\frac{e}{2m} \left\{ \psi_i^* \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right) \psi_i + c.c. \right\}$$

We first consider description of electronic motion for a given electric field, $\mathbf{E}(t)$.

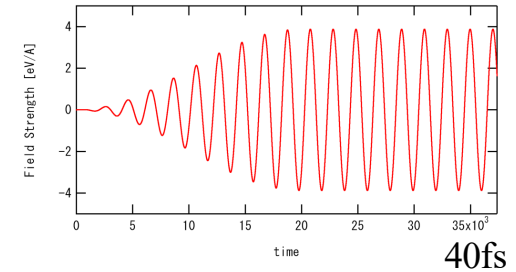
Atoms irradiated by strong pulsed electric field

Electron rescattering and high harmonic generation by TDDFT

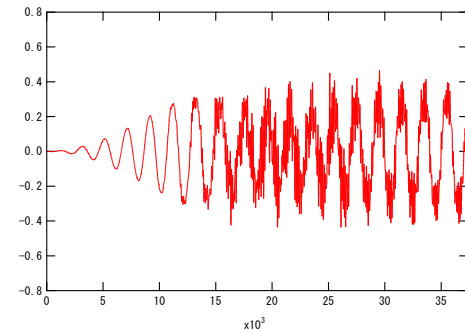


Ar atom
 $2 \times 10^{14} \text{W/cm}^2$
800nm
TDDFT(ALDA)

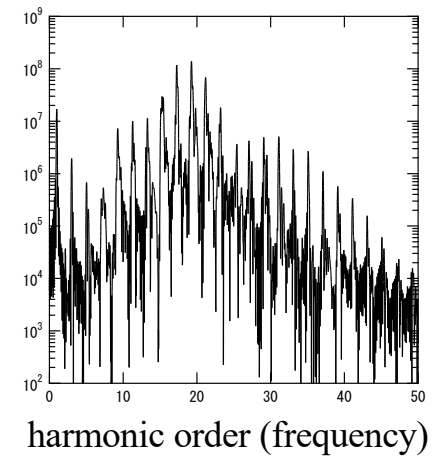
Applied laser field



$$\frac{dD(t)}{dt} = \frac{d}{dt} \int d\vec{r} z \rho(\vec{r}, t)$$



$$I(\omega) \propto \left| \int dt e^{i\omega t} d_A(t) \right|^2$$



Time-dependent Kohn-Sham equation

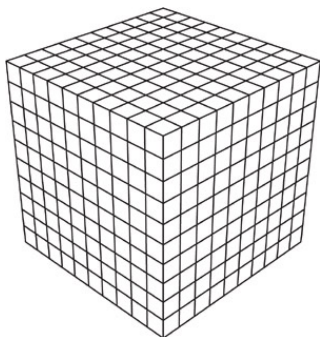
$$i\hbar \frac{\partial}{\partial t} \psi_i(\mathbf{r}, t) = \left\{ -\frac{\hbar^2}{2m} \nabla^2 + V_{\text{ion}}(\mathbf{r}) + \int d\mathbf{r}' \frac{e^2}{|\mathbf{r} - \mathbf{r}'|} \rho(\mathbf{r}', t) + \mu_{xc}(\mathbf{r}, t) + V_{\text{ext}}(\mathbf{r}, t) \right\} \psi_i(\mathbf{r}, t)$$

$$\rho(\mathbf{r}, t) = \sum_i |\psi_i(\mathbf{r}, t)|^2$$

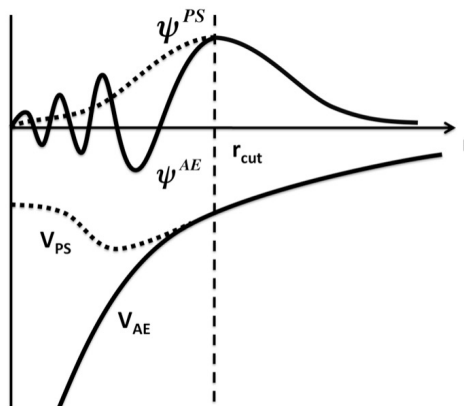
$$V_{\text{ext}}(\mathbf{r}, t) = e\mathbf{E}(t) \cdot \mathbf{r}$$

Numerical method adopted throughout my presentation

Real-space uniform grid



Norm-conserving pseudopotential



High order finite difference (9pts)
for spatial derivative

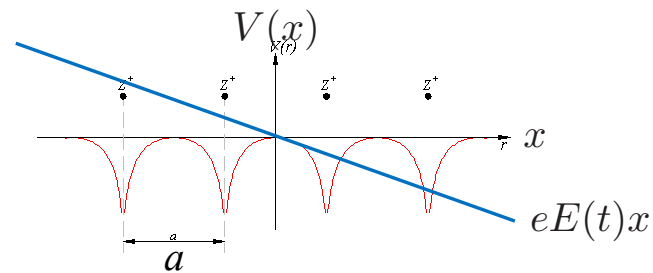
Explicit method for time evolution

$$\begin{aligned} \psi(t + \Delta t) &= e^{iH\Delta t/\hbar} \psi(t) \\ &\approx \sum_{k=0}^N \left(\frac{1}{k!} \frac{i\Delta t H}{\hbar} \right)^k \psi(t) \end{aligned}$$

Crystalline solids irradiated by strong pulsed electric field

The potential $eE(t)x$ is called “length gauge”.

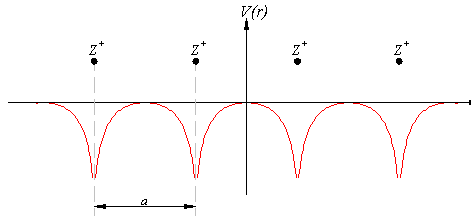
In this “length gauge”, lattice periodicity is violated so that Bloch theorem cannot be applied.



$$V(x + a) \neq V(x)$$

We will make use of gauge freedom to overcome the problem.

Gauge transformation: from “length gauge” to “velocity gauge”



Length gauge

$$i\hbar \frac{\partial}{\partial t} \psi = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} \right)^2 + V(\vec{r}) + \underline{e\vec{E}(t) \cdot \vec{r}} \right\} \psi$$



$$\psi' = \exp \left[\frac{ie}{\hbar c} \vec{A}(t) \cdot \vec{r} \right] \psi$$

$$\vec{E}(t) = -\frac{1}{c} \frac{d\vec{A}(t)}{dt}$$

Gauge transformation
using time-dependent,
spatially-uniform vector potential

Velocity gauge

$$i\hbar \frac{\partial}{\partial t} \psi' = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \underline{\frac{e}{c} \vec{A}(t)} \right)^2 + V(\vec{r}) \right\} \psi'$$

Expressing uniform electric field by vector potential,
lattice periodicity of Hamiltonian is recovered.

$$h(\vec{r} + \vec{a}) = h(\vec{r})$$

Time-Dependent Kohn-Sham equation in velocity gauge

$$i\hbar \frac{\partial}{\partial t} \psi_i(\vec{r}, t) = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \frac{e}{c} \vec{A}(t) \right)^2 - \sum_a \frac{Z_a e^2}{|\vec{r} - \vec{R}_a|} + \int d\vec{r}' \frac{e^2}{|\vec{r} - \vec{r}'|} \rho(\vec{r}', t) + \mu_{xc}[\rho(\vec{r}, t)] \right\} \psi_i(\vec{r}, t)$$

$$\rho(\vec{r}, t) = \sum_i |\psi_i(\vec{r}, t)|^2$$

At each time, we may apply the Bloch's theorem

$$\psi_i(\vec{r}, t) = e^{i\vec{k}\vec{r}} u_{n\vec{k}}(\vec{r}, t)$$

$$i\hbar \frac{\partial}{\partial t} u_{n\vec{k}}(\vec{r}, t) = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \hbar\vec{k} + \frac{e}{c} \vec{A}(t) \right)^2 - \sum_a \frac{Z_a e^2}{|\vec{r} - \vec{R}_a|} + \int d\vec{r}' \frac{e^2}{|\vec{r} - \vec{r}'|} \rho(\vec{r}', t) + \mu_{xc}[\rho(\vec{r}, t)] \right\} u_{n\vec{k}}(\vec{r}, t)$$

$$u_{n\vec{k}}(\vec{r} + \vec{a}, t) = u_{n\vec{k}}(\vec{r}, t)$$

Further gauge transformation is possible in Bloch's space

Original length gauge $i\hbar \frac{\partial}{\partial t} \psi = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} \right)^2 + V(\vec{r}) + e\vec{E}(t) \cdot \vec{r} \right\} \psi$


 $\psi' = \exp \left[\frac{ie}{\hbar c} \vec{A}(t) \cdot \vec{r} \right] \psi$

Velocity gauge $i\hbar \frac{\partial}{\partial t} \psi' = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \frac{e}{c} \vec{A}(t) \right)^2 + V(\vec{r}) \right\} \psi' \quad \vec{E}(t) = -\frac{1}{c} \frac{d\vec{A}(t)}{dt}$



Time-dependent Bloch (Kohn-Sham) equation

$$i\hbar \frac{\partial}{\partial t} u_{n\vec{k}} = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \hbar \vec{k} + \frac{e}{c} \vec{A}(t) \right)^2 + V(\vec{r}) \right\} u_{n\vec{k}}$$



$$u'_{n\vec{k}}(\vec{r}, t) = \exp \left[-\frac{e}{\hbar c} \vec{A}(t) \vec{\nabla}_k \right] u_{n\vec{k}}(\vec{r}, t)$$

Dynamical Berry phase theory

C. Attaccalite, M. Grüning,
Phys. Rev. B88, 235113 (2013)
I. Souza, J. Iniguez, D. Vanderbilt,
Phys. Rev. 69, 085106 (2004)

**Length-gauge
in k-space**

$$i\hbar \frac{\partial}{\partial t} u'_{n\vec{k}} = \left\{ \frac{1}{2m} \left(-i\hbar \vec{\nabla} + \hbar \vec{k} \right)^2 + V(\vec{r}) + ie\vec{E}(t) \vec{\nabla}_k \right\} u'_{n\vec{k}}$$

Length operator in k-space $\vec{r} \rightarrow i\vec{\nabla}_k$


 $e\vec{E}(t) \cdot \vec{r}$

Real-time TDDFT in a unit cell of silicon under strong laser pulse

Static DFT: Band calculation

$$\varepsilon_{nk} u_{nk}(r) = \left[\frac{1}{2m} (p + \hbar k)^2 + V_H(r) + V_{xc}(r) \right] u_{nk}(r)$$



TDDFT: Electron dynamics

$$i\hbar \frac{\partial}{\partial t} u_{nk}(r, t) = \left[\frac{1}{2m} \left(p + \hbar k + \frac{e}{c} \mathbf{A}(t) \right)^2 + V_H(r, t) + V_{xc}(r, t) \right] u_{nk}(r, t)$$

$$\mathbf{A}(t) = -c \int^t E(t') dt'$$

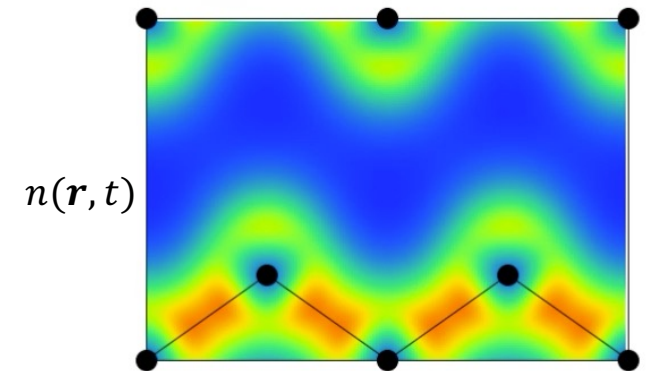
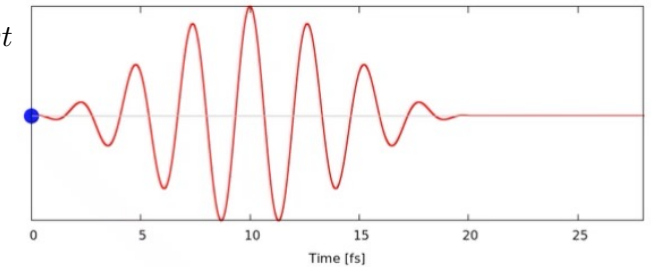
$$\mathbf{j} = -\frac{e}{2m} \left\{ \psi_i^* \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right) \psi_i + c.c. \right\}$$

$$E(t) = E_0 \cos^2 \left(\frac{\pi t}{T} \right) \cos \omega t$$

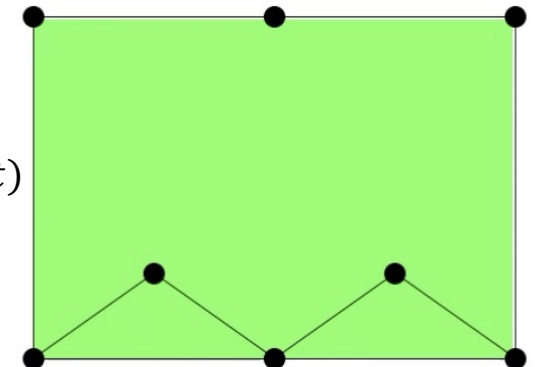
$$E_0 = 2.0 \text{ [V/\AA]}$$

$$\hbar\omega = 1.55 \text{ [eV]}$$

$$T = 20 \text{ [fs]}$$



$$n(r, t) - n_{GS}(r, t)$$



G.F. Bertsch, J.-I. Iwata, A. Rubio, K. Yabana, Phys. Rev. B62, 7998 (2000)

T. Otake, M. Yamagiwa, J.-I. Iwata, K. Yabana, T. Nakatsukasa, K. Yabana, Phys. Rev. B77, 165104 (2008)

Real-time TDDFT in a unit cell of silicon under strong laser pulse

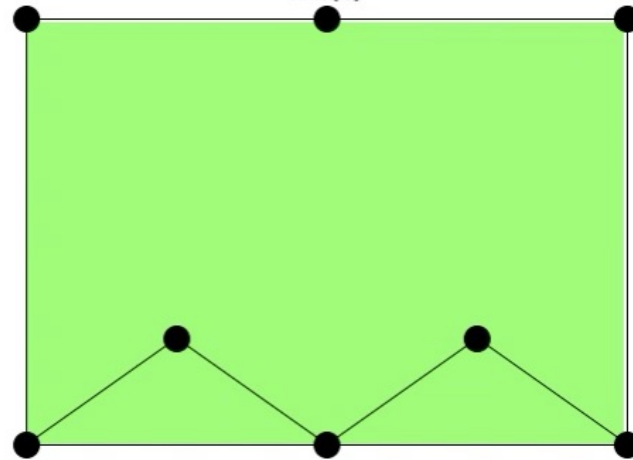
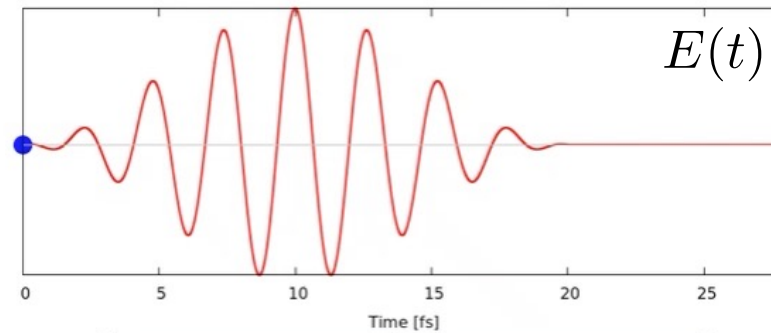
Electric field

$$E(t) = E_0 \cos^2\left(\frac{\pi t}{T}\right) \cos \omega t$$

$$E_0 = 2.0 \text{ [V/\AA]}$$

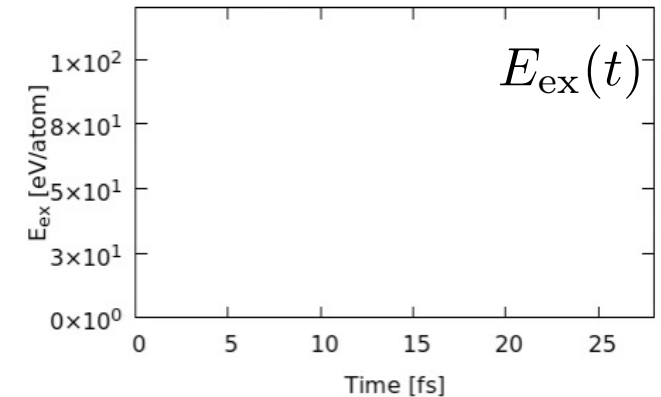
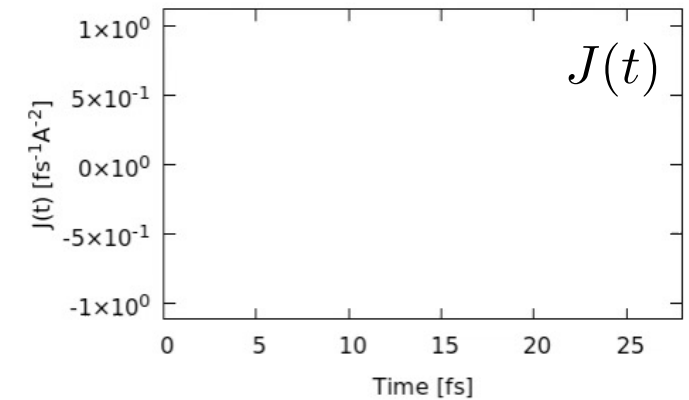
$$\hbar\omega = 1.55 \text{ [eV]}$$

$$T = 20 \text{ [fs]}$$



$$\Delta\rho(\mathbf{r}, t) = \rho(\mathbf{r}, t) - \rho_0(\mathbf{r})$$

Current density



Electronic excitation energy

Real time calculation of dielectric function

G.F. Bertsch, J.-I. Iwata, A. Rubio, K. Yabana, Phys. Rev. B62, 7998 (2000)

K. Yabana, T. Sugiyama, Y. Shinohara, T. Otobe, G.F. Bertsch, Phys. Rev. B85, 045134 (2012)

Applied electric field and induced current

$$J(t) = \int^t dt' \underbrace{\sigma(t-t')}_{\text{Electric conductivity}} E(t')$$

$$\epsilon(\omega) = 1 + 4\pi\chi(\omega) = 1 + \frac{4\pi i\sigma(\omega)}{\omega}$$

Apply impulsive force to all electrons in the crystal

$$F_{ext}(t) = -eE(t) = I\delta(t) \quad A(t) = -c \int^t dt' E(t') = A_0\theta(t) \quad A_0 = \frac{c}{e}I$$

$$v_{n\mathbf{k}}(\mathbf{r}, t = 0_+) = u_{n\mathbf{k} + \frac{e\mathbf{A}_0}{\hbar c}}(\mathbf{r})$$

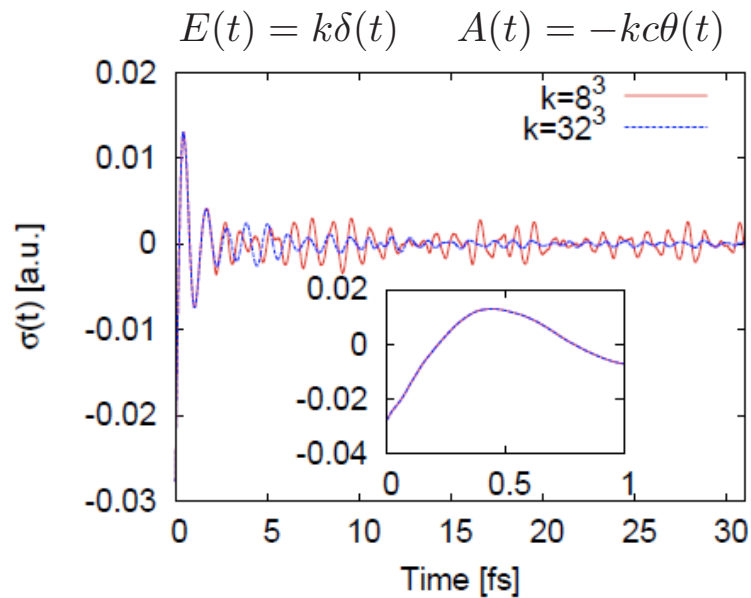
Impulse = shift of crystal momentum, k

Induced current is proportional to conductivity in time domain

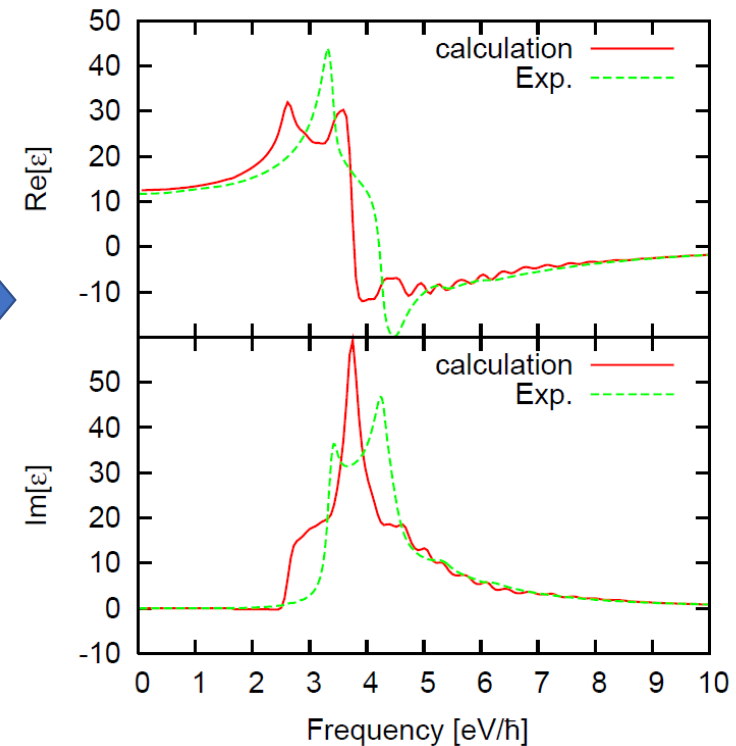
$$J(t) = \int dt' \sigma(t-t') E(t') = \frac{I}{-e} \sigma(t)$$

Real-time calculation of dielectric function of silicon (TDDFT-ALDA)

Current as a function of time after impulse



Dielectric function



Quality not sufficient by ALDA

For the first-principles calculation of dielectric function,
 “GW + Bethe-Salpeter” is the state-of-the-art.

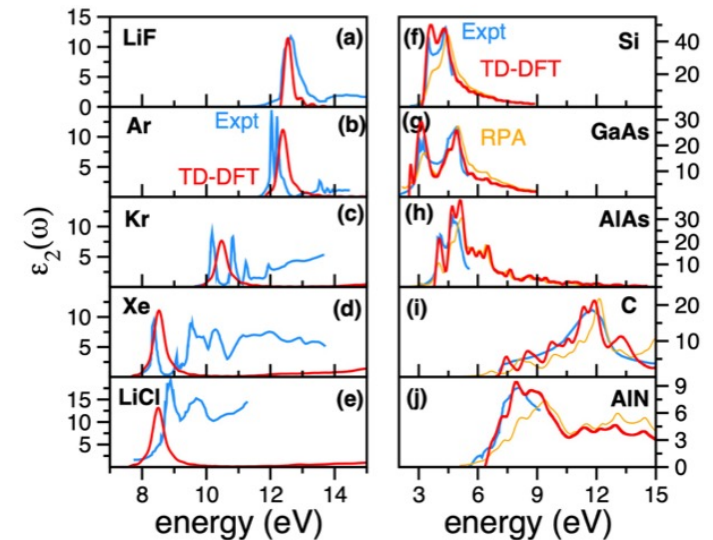
Efforts to improve “exchange-correlation potential” in TDDFT
 have continued for many years.

Improvement through $\mathbf{A}_{xc}(t)$ is considered to be important

$$i\hbar \frac{\partial}{\partial t} u_{n\mathbf{k}}(\mathbf{r}, t) = \left\{ -\frac{1}{2m} \left(-i\hbar \nabla + \hbar \mathbf{k} + \frac{e}{c} \mathbf{A}(t) \right)^2 + V_{\text{ion}}(\mathbf{r}) + V_{\text{H}}(\mathbf{r}, t) + V_{\text{xc}}(\mathbf{r}, t) \right\} u_{n\mathbf{k}}(\mathbf{r}, t)$$

$$\mathbf{A}_{ext}(t) + \mathbf{A}_{xc}(t)$$

Necessary for extended systems



$$a_2 \frac{\partial^2}{\partial t^2} \mathbf{A}_{xc}(t) + a_0 \mathbf{A}_{xc}(t) = \frac{4\pi c}{\Omega} \mathbf{J}(t).$$

J.K. Dewhurst, D. Gill, S. Shallcross, S. Sharma,
 Phys. Rev. B111, L060302 (2025)

**When connecting Maxwell/Schrödinger necessary?
= when incident pulse is modulated by matter?**

Not necessary

Atoms

Molecules

**Small nanoparticles
($< \text{a few nm radius}$)**

Marginal

**Monoatomic layer
(e.g. Graphene)**

Single layer of graphene
absorbs 2.3% of incident light

- Single layer: not necessary
- Ten layers: necessary

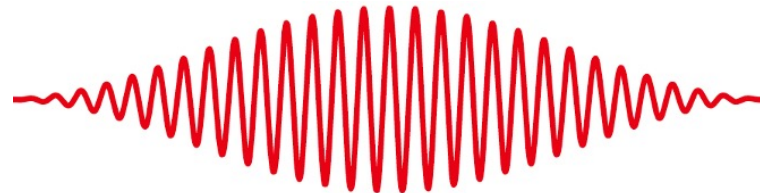
Necessary

**films
($> \text{a few tens nm thick}$)**

**Nanoparticles
($> \text{a few tens nm radius}$)**

Bulk surfaces

Wavelength of visible light
 $\sim 1 \mu\text{m}$ (1000 nm)



Directly connect EM and QM

Light propagation solving
classical Maxwell's equations

$$\nabla \times \nabla \times \mathbf{A} + \frac{1}{c^2} \frac{\partial^2}{\partial t^2} \mathbf{A} = \frac{4\pi}{c} \mathbf{j}$$

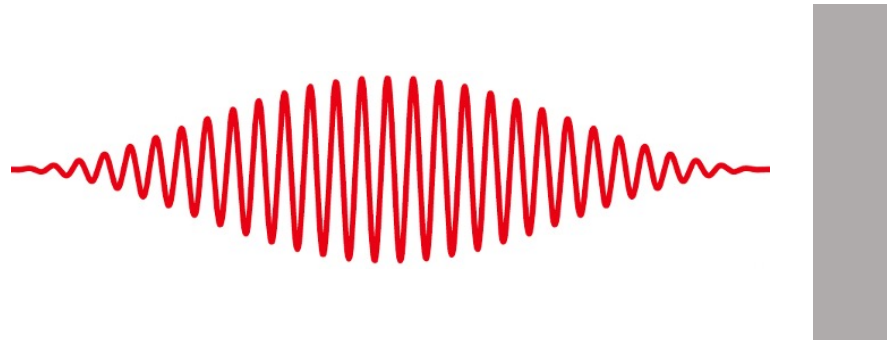
Electron dynamics by TDDFT in real time

$$i\hbar \frac{\partial}{\partial t} \psi_i = \left\{ \frac{1}{2m} \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right)^2 + V_{ion} + V_H + V_{xc} \right\} \psi_i$$
$$\mathbf{j} = -\frac{e}{2m} \left\{ \psi_i^* \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right) \psi_i + c.c. \right\}$$

We develop two methods, without/with coarse-graining.

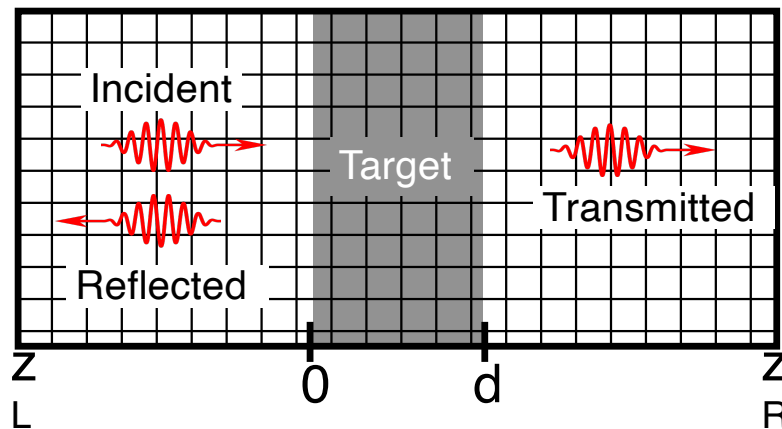
Microscopic (single-grid) vs Macroscopic (multi-grid)

**I will consider an irradiation of a thin material
by a pulsed light at normal incidence**



Microscopic (Single-scale) vs. Macroscopic (Multi-scale)

Microscopic Maxwell+TDDFT



$$i \frac{\partial}{\partial t} u_{n\mathbf{k}} = \hat{H}_{\mathbf{k} + \frac{1}{c} \mathbf{A}(\mathbf{r}, t)} u_{n\mathbf{k}}$$

$$\left(\frac{1}{c^2} \frac{\partial^2}{\partial t^2} - \nabla^2 \right) \mathbf{A}(\mathbf{r}, t) + \frac{1}{c} \nabla \dot{\phi}(\mathbf{r}, t) = -\frac{4\pi}{c} \mathbf{j}_e(\mathbf{r}, t)$$

$$\nabla^2 \phi(\mathbf{r}, t) = 4\pi n_e(\mathbf{r}, t)$$

Single-scale approach using a common spatial grid

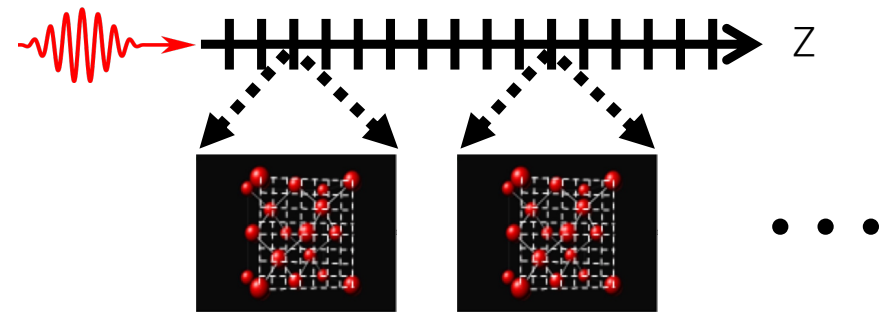
nonlocal + nonlinear

S. Yamada *et al*, PRB **98**, 245147 (2018).

Macroscopic Maxwell+TDDFT

$$\left(\frac{1}{c^2} \frac{\partial^2}{\partial t^2} - \frac{\partial^2}{\partial Z^2} \right) \mathbf{A}_Z(t) = \frac{4\pi}{c} \mathbf{J}_Z(t)$$

grid spacing ~ 10 nm



nm-scale grid #1

nm-scale grid #2

$$i \frac{\partial}{\partial t} u_{n\mathbf{k}, Z} = \hat{H}_{\mathbf{k} + \frac{1}{c} \mathbf{A}_Z(t)} u_{n\mathbf{k}, Z}$$

$$i \frac{\partial}{\partial t} u_{n\mathbf{k}, Z} = \hat{H}_{\mathbf{k} + \frac{1}{c} \mathbf{A}_Z(t)} u_{n\mathbf{k}, Z}$$

Multiscale approach using different spatial grid

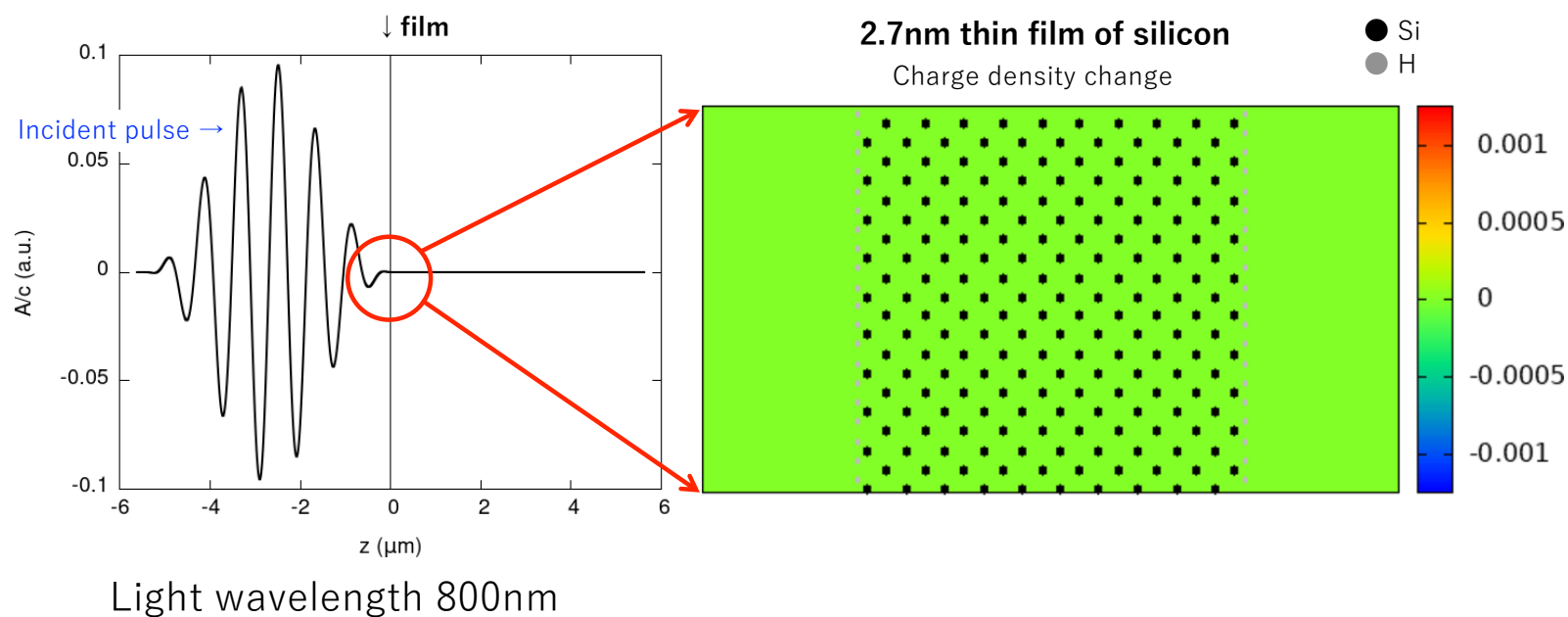
nonlinear only

K. Yabana *et al*., PRB **85**, 045134 (2012).

Microscopic (single-scale) Maxwell-TDDFT: pulsed light on Si nano-film

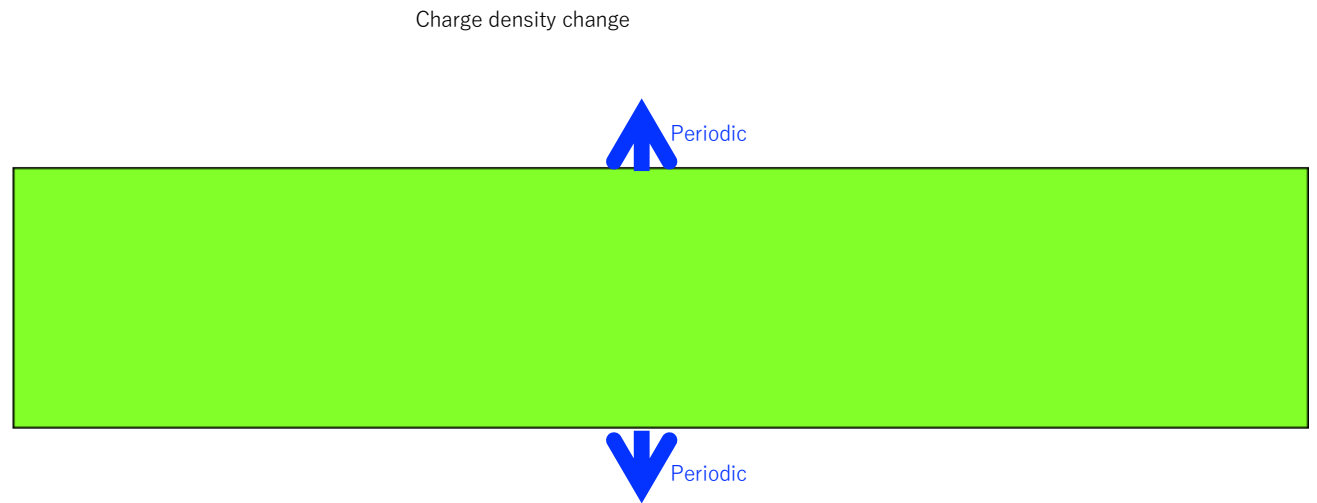
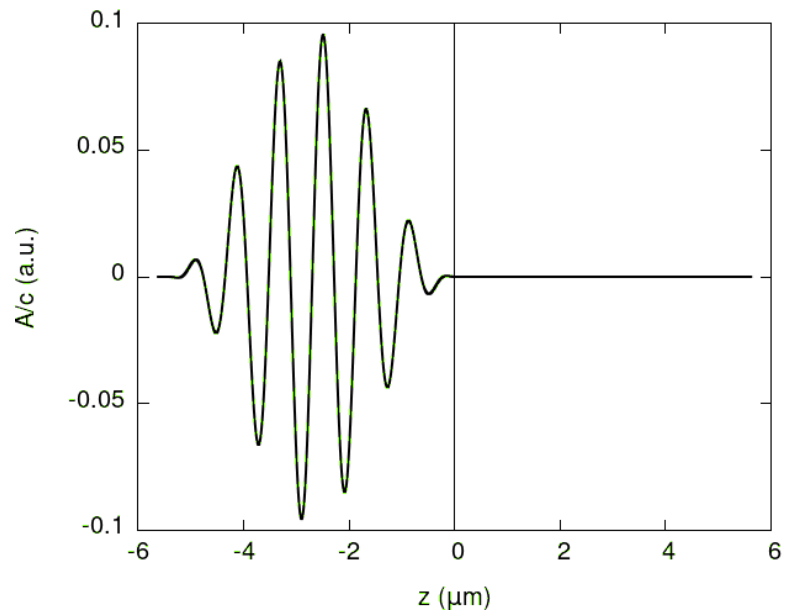


Shunsuke Yamada
Kansai Photon Sci. Inst



Thicker film (27.2nm)

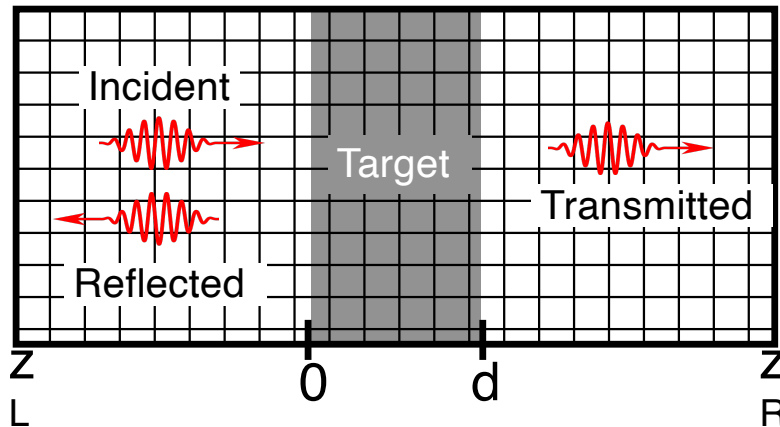
Light pulse: $\hbar\omega = 1.5\text{eV}$, $I = 10^{12}\text{W/cm}^2$, $T = 18\text{fs}$



**Max. possible thickness $\sim 50\text{nm}$
limited by computational capability**

Microscopic (Single-scale) vs. Macroscopic (Multi-scale)

Microscopic Maxwell+TDDFT



$$i\frac{\partial}{\partial t}u_{n\mathbf{k}} = \hat{H}_{\mathbf{k}+\frac{1}{c}\mathbf{A}(\mathbf{r},t)}u_{n\mathbf{k}}$$

$$\left(\frac{1}{c^2}\frac{\partial^2}{\partial t^2} - \nabla^2\right)\mathbf{A}(\mathbf{r},t) + \frac{1}{c}\nabla\dot{\phi}(\mathbf{r},t) = -\frac{4\pi}{c}\mathbf{j}_e(\mathbf{r},t)$$

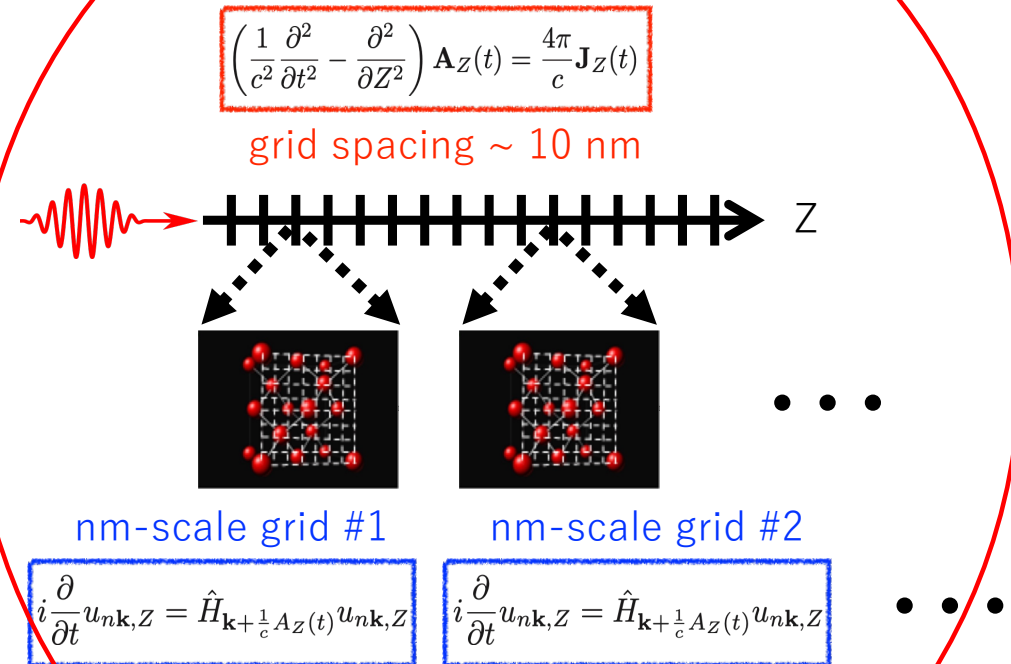
$$\nabla^2\phi(\mathbf{r},t) = 4\pi n_e(\mathbf{r},t)$$

Single-scale approach using a common spatial grid

nonlocal + nonlinear

S. Yamada *et al*, PRB **98**, 245147 (2018).

Macroscopic Maxwell+TDDFT



$$\left(\frac{1}{c^2}\frac{\partial^2}{\partial t^2} - \frac{\partial^2}{\partial Z^2}\right)\mathbf{A}_Z(t) = \frac{4\pi}{c}\mathbf{J}_Z(t)$$

grid spacing ~ 10 nm

nm-scale grid #1

nm-scale grid #2

$$i\frac{\partial}{\partial t}u_{n\mathbf{k},Z} = \hat{H}_{\mathbf{k}+\frac{1}{c}\mathbf{A}_Z(t)}u_{n\mathbf{k},Z}$$

$$i\frac{\partial}{\partial t}u_{n\mathbf{k},Z} = \hat{H}_{\mathbf{k}+\frac{1}{c}\mathbf{A}_Z(t)}u_{n\mathbf{k},Z}$$

Multiscale approach using different spatial grid

nonlinear only

K. Yabana *et al*., PRB **85**, 045134 (2012).

Macroscopic (multi-scale) Maxwell-TDDFT: pulsed light on 1 μm Si film

Change of electron density
from ground state

$$\Delta n(\mathbf{r}, t) = n(\mathbf{r}, t) - n_{GS}(\mathbf{r})$$

Front

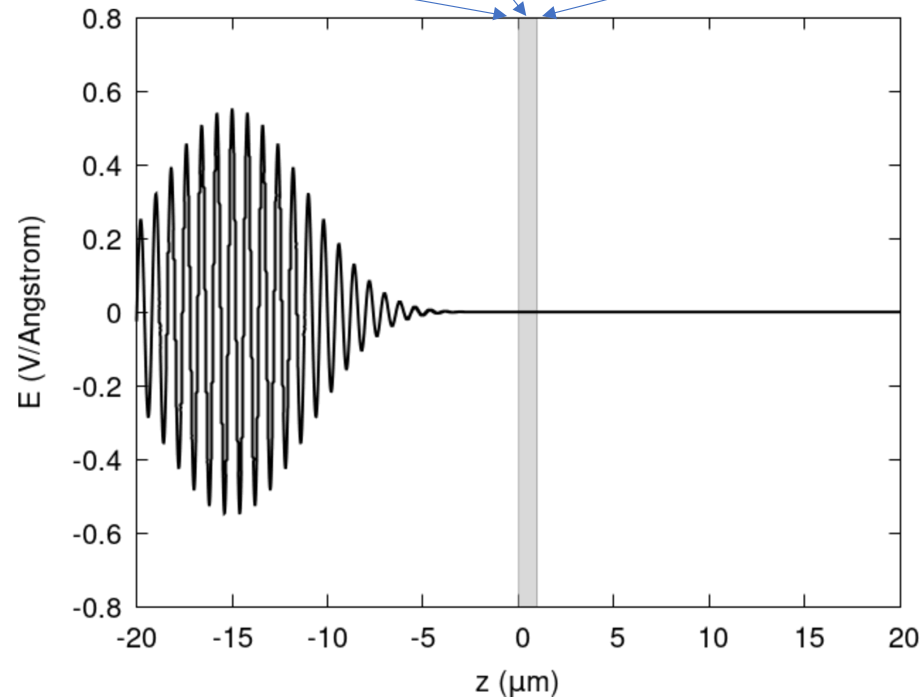
Middle

Back

~200 grid points
for 1 μm film

Thin film
Silicon, 1 μm thick

Laser pulse
800nm (1.55eV=below gap)
 $4 \times 10^{12} \text{W}/\text{cm}^2$

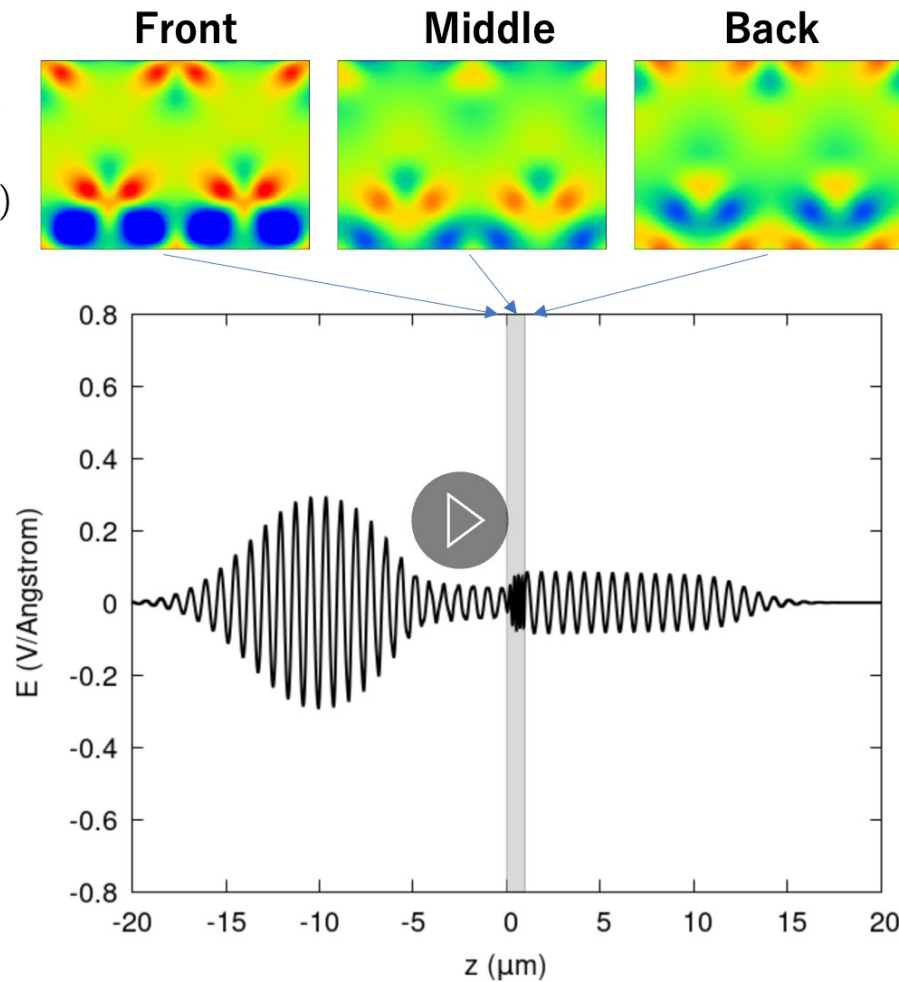


Macroscopic (multi-scale) Maxwell-TDDFT: pulsed light on 1 μ m Si film

Thin film
Silicon, 1 μ m thick

Laser pulse
800nm (1.55eV=below gap)
 $4 \times 10^{12} \text{W/cm}^2$

Change of electron density
from ground state
 $\Delta n(\mathbf{r}, t) = n(\mathbf{r}, t) - n_{GS}(\mathbf{r})$



Today I will talk on:

- Solve Maxwell and Schrödinger (time-dependent Kohn-Sham) equations simultaneously.
- Directly connecting electromagnetism and quantum mechanics.

Classical electromagnetic fields

$$\nabla \times \nabla \times \mathbf{A} + \frac{1}{c^2} \frac{\partial^2}{\partial t^2} \mathbf{A} = \frac{4\pi}{c} \mathbf{j}$$

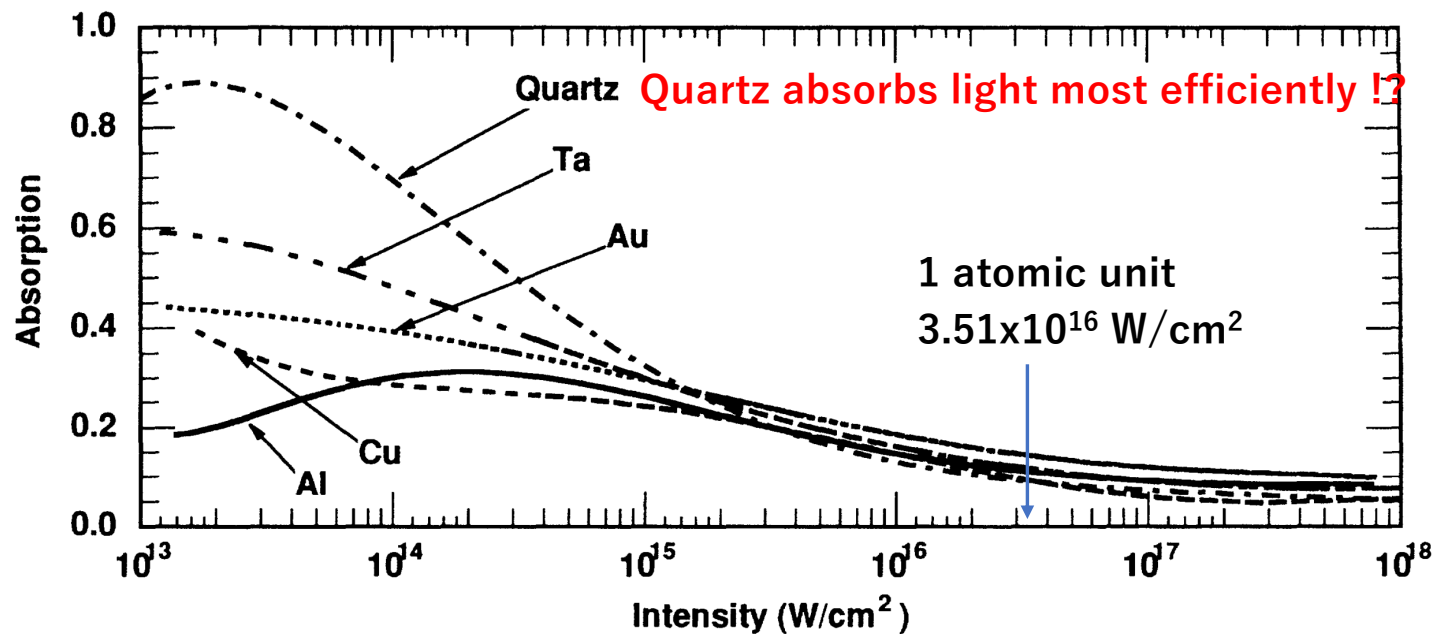
Quantum electronic motion

$$i\hbar \frac{\partial}{\partial t} \psi_i = \left\{ \frac{1}{2m} \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right)^2 + V_{ion} + V_H + V_{xc} \right\} \psi_i$$
$$\mathbf{j} = -\frac{e}{2m} \left\{ \psi_i^* \left(-i\hbar \nabla + \frac{e}{c} \mathbf{A} \right) \psi_i + c.c. \right\}$$

- Why and where it is necessary?
- How it is carried out?
- How it works?

High intensity laser pulse on various materials : Systematics

Strong pulsed light irradiates on solid surface.
Reflection and absorption take place.



Experiment at LLNL, using 120fs pulse

D.F.Price et al., *Phys.Rev.Lett.* **75**,252 (1995)



Atsushi Yamada
Defence Academy

High intensity laser pulse on various materials : Systematics

Multiscale Maxwell-TDDFT calculation

A. Yamada, K. Yabana, *Phys. Rev. B*109, 245130 (2024)

Experiment at LLNL, using 120fs pulse

D.F.Price et al., *Phys.Rev.Lett.*75,252 (1995)

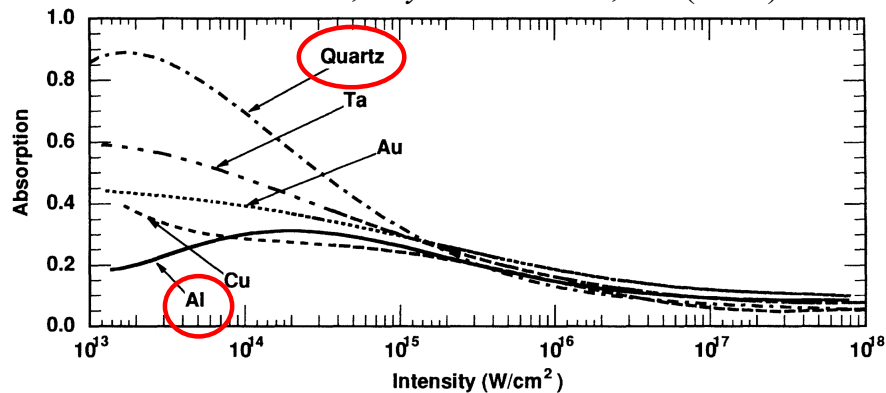
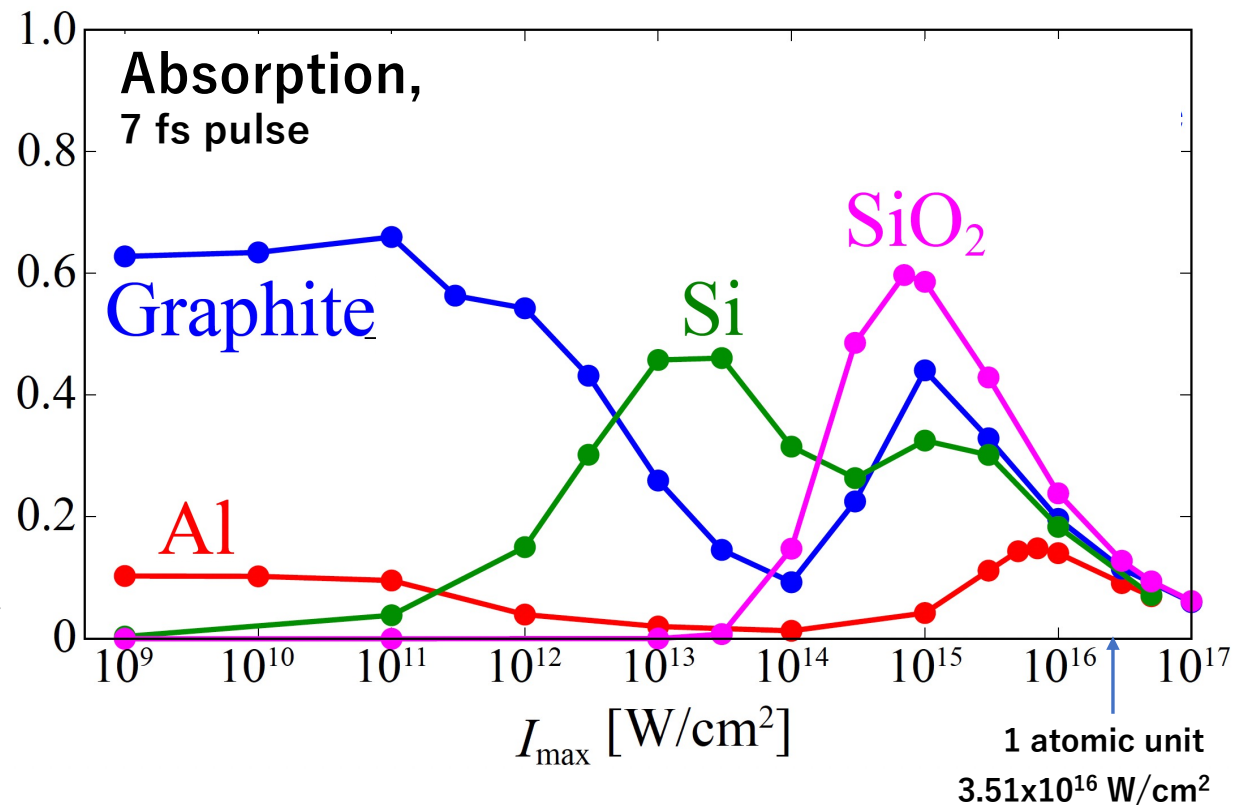
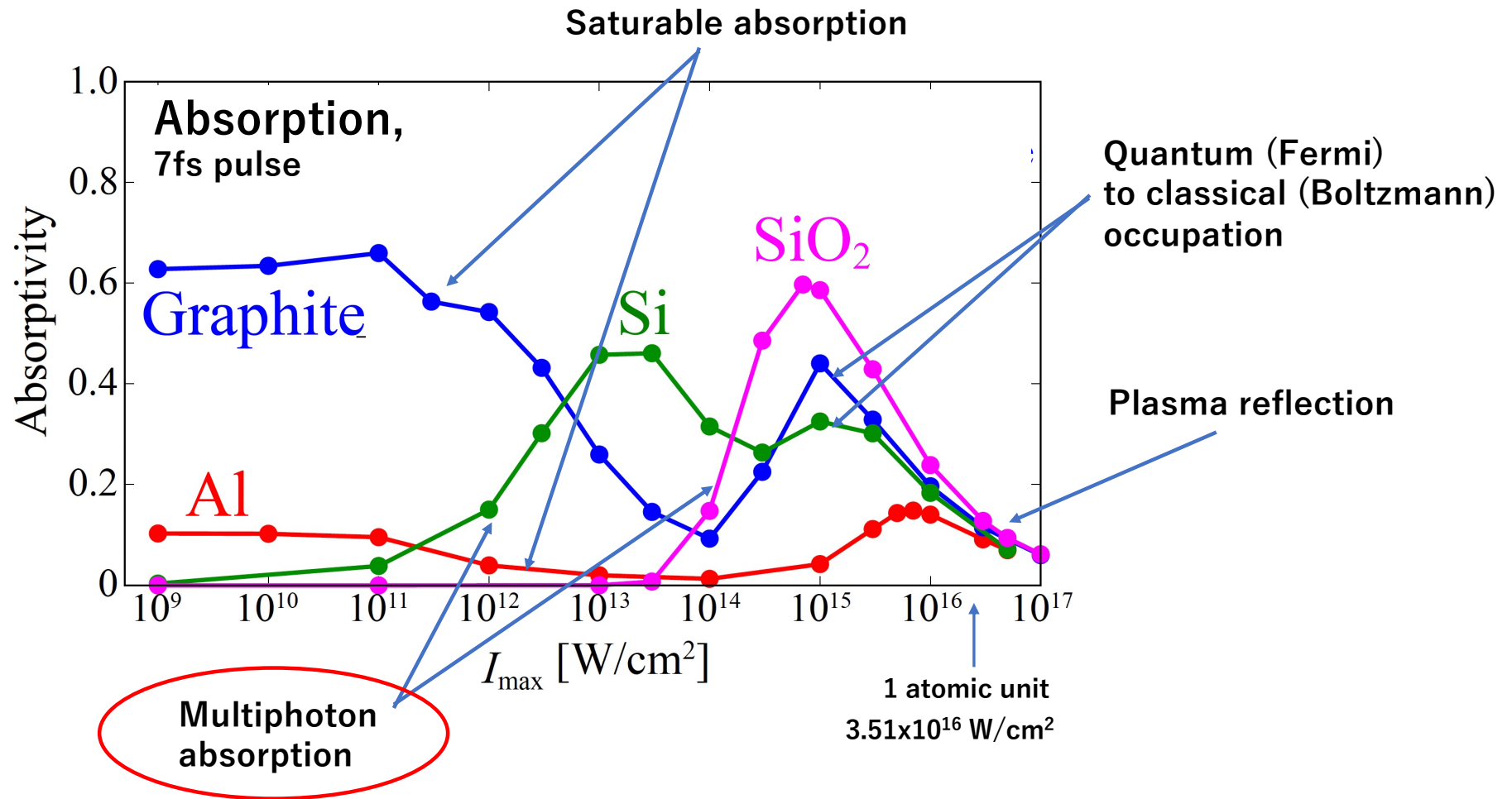


FIG. 1. Absorption fraction vs peak laser intensity for aluminum, copper, gold, tantalum, and quartz targets. In Figs. 1, 3, 4, and 5 laser intensity is the temporal and spatial peak value of the laser intensity.

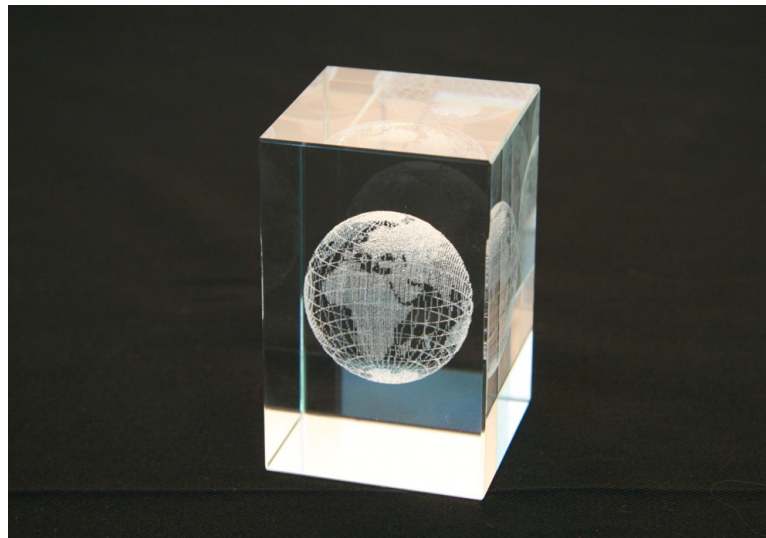


Nonlinear optical response: Mechanisms



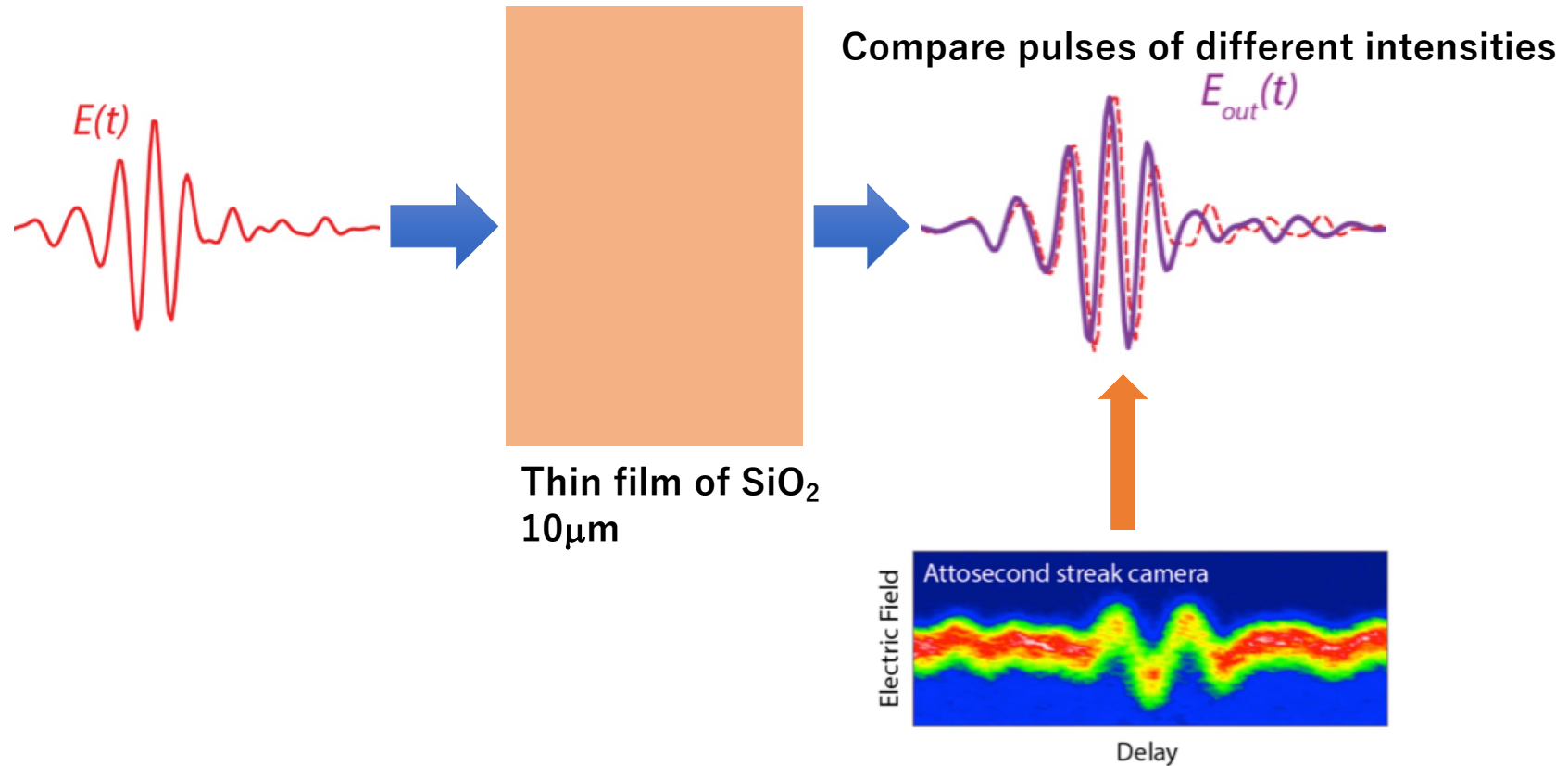
At which intensity of light, glass starts to absorb light?

Laser processing of dielectrics



Calculation for SiO_2 (alpha-quartz)

Laser pulse propagation through SiO₂ 10μm thin film



EXP: Attosecond streaking measurements
by Max Planck Inst. Quantum Optics

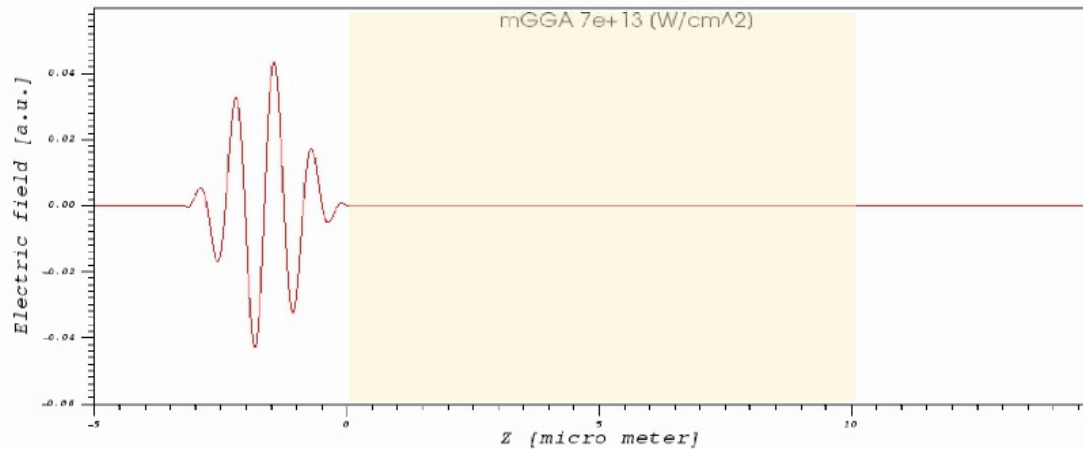
Maxwell + TDDFT multiscale simulation : 10 μm SiO_2

$$\hbar\omega = 1.55\text{eV}$$

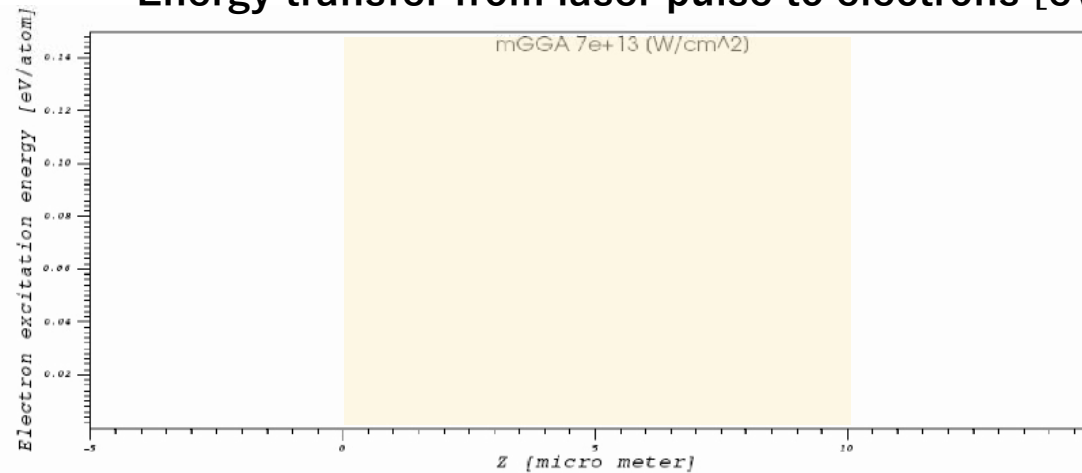
$$\lambda = 800\text{nm}$$

$$I = 7 \times 10^{13} \text{W/cm}^2$$

Laser electric field, **red (strong)**, **blue (weak)**



Energy transfer from laser pulse to electrons [eV/atom]

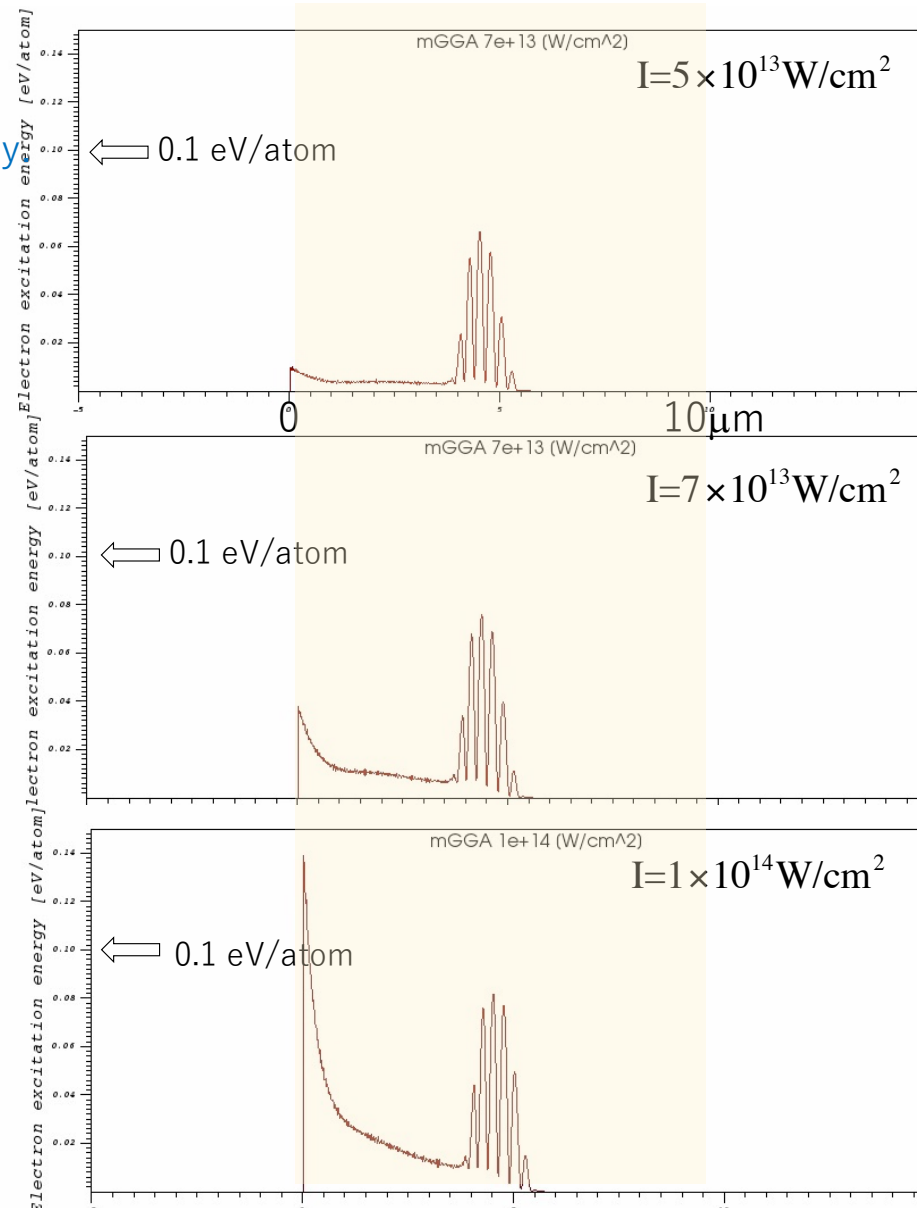
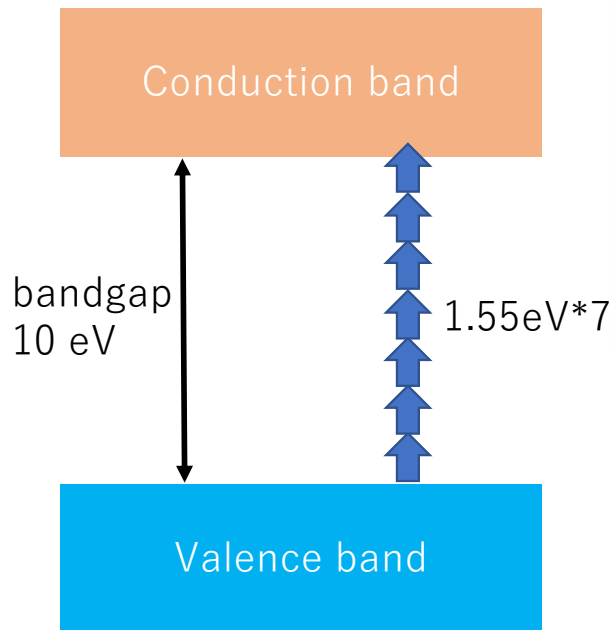


80,000 cores, 20 hours
at K-Computer, Kobe

Energy deposited to electrons in SiO₂
increases rapidly at a certain laser intensity

>> Damage threshold

Multiphoton/Tunneling excitation

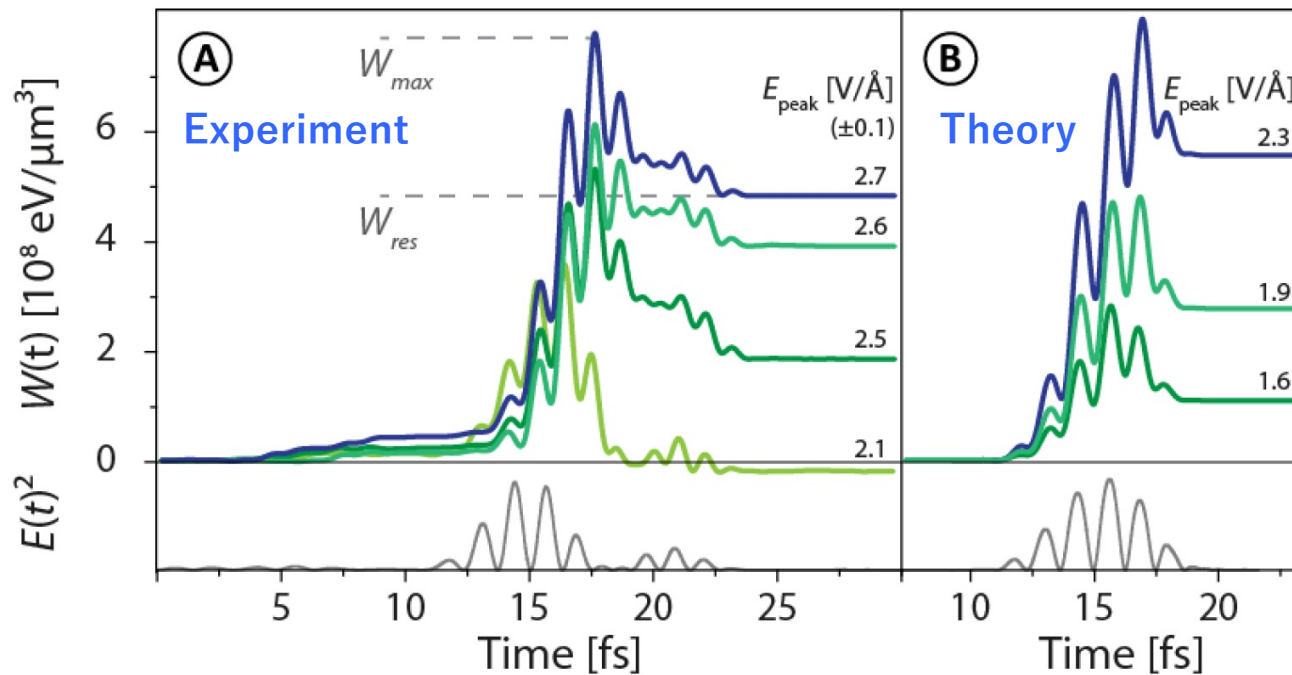




Shunsuke Sato
Tohoku U.

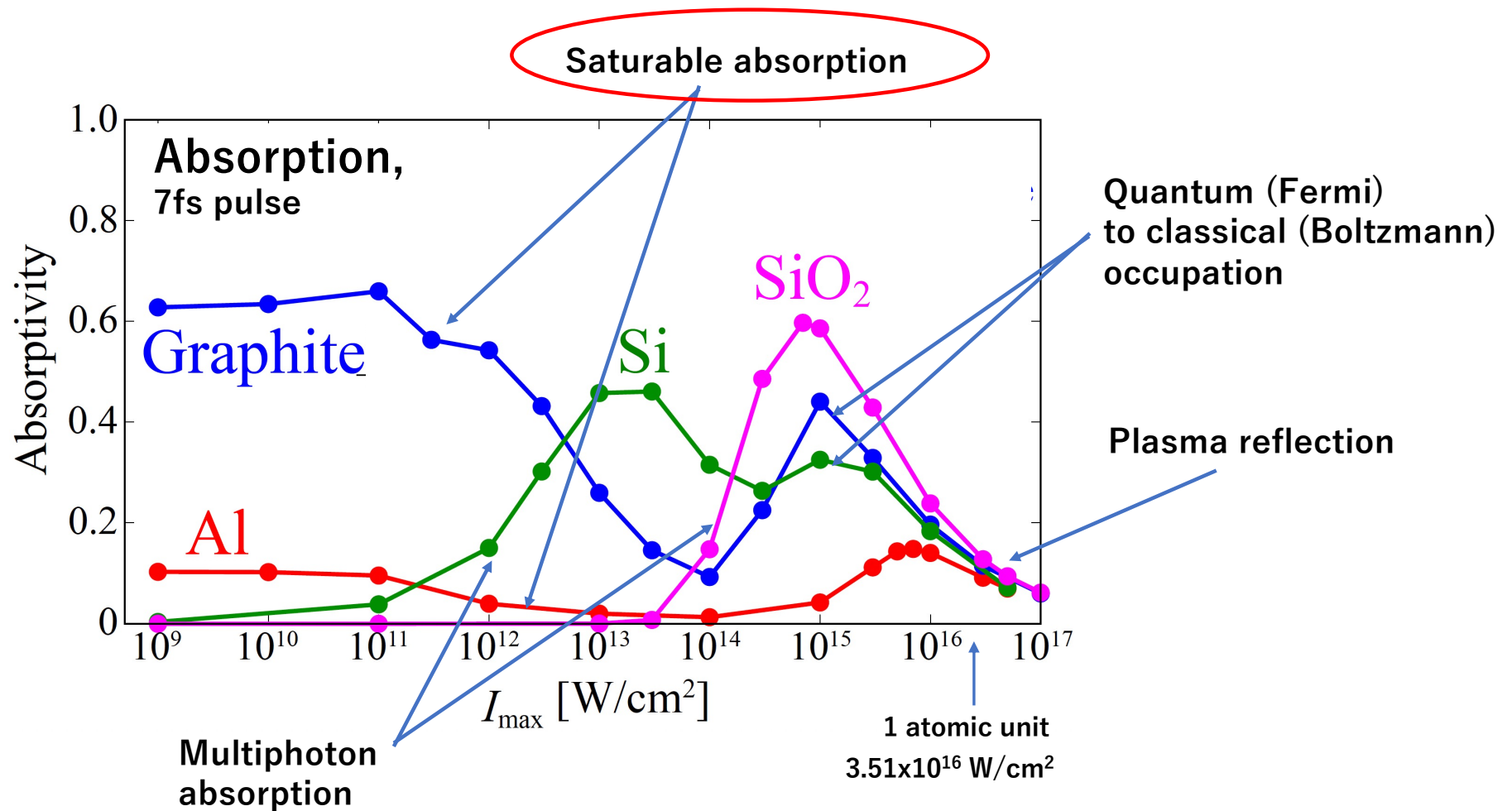
Comparison between theory and experiment

Energy deposition from laser pulse to SiO₂ at mid point (5μm)

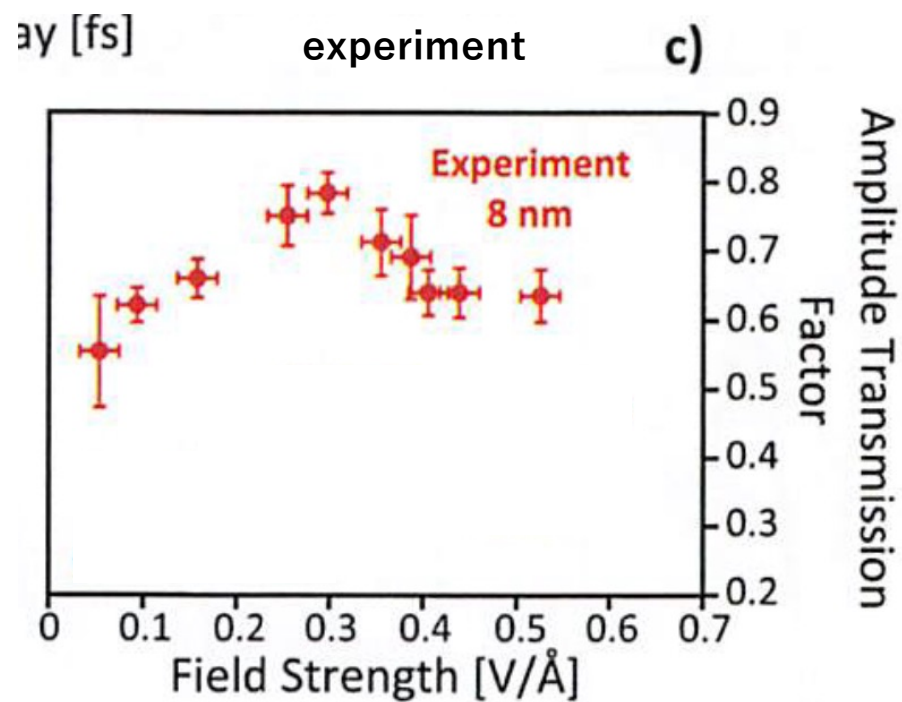


A. Sommer et.al, Nature 534, 86 (2016).
(EXP: Max Planck Institute for Quantum Optics)

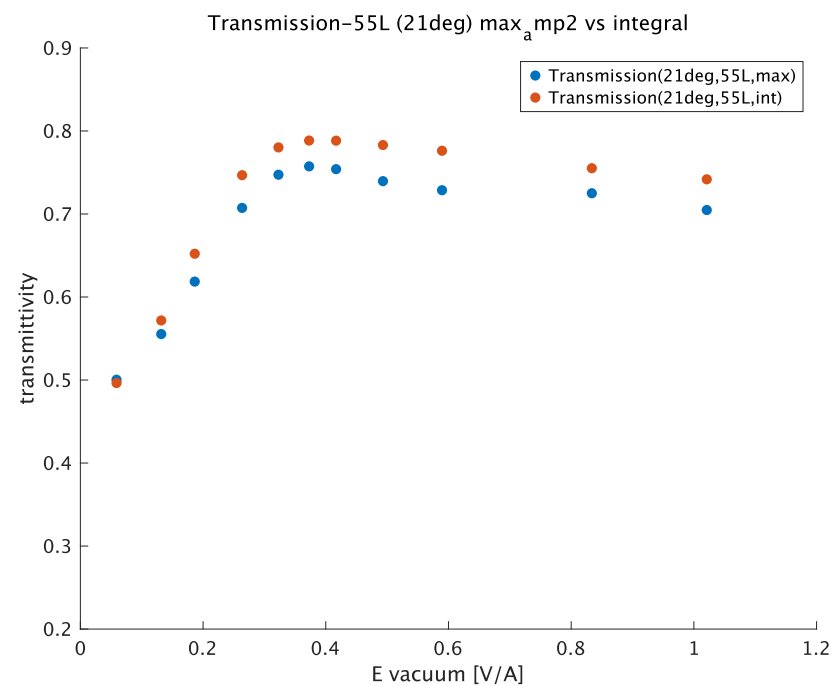
Nonlinear optical response: Mechanisms



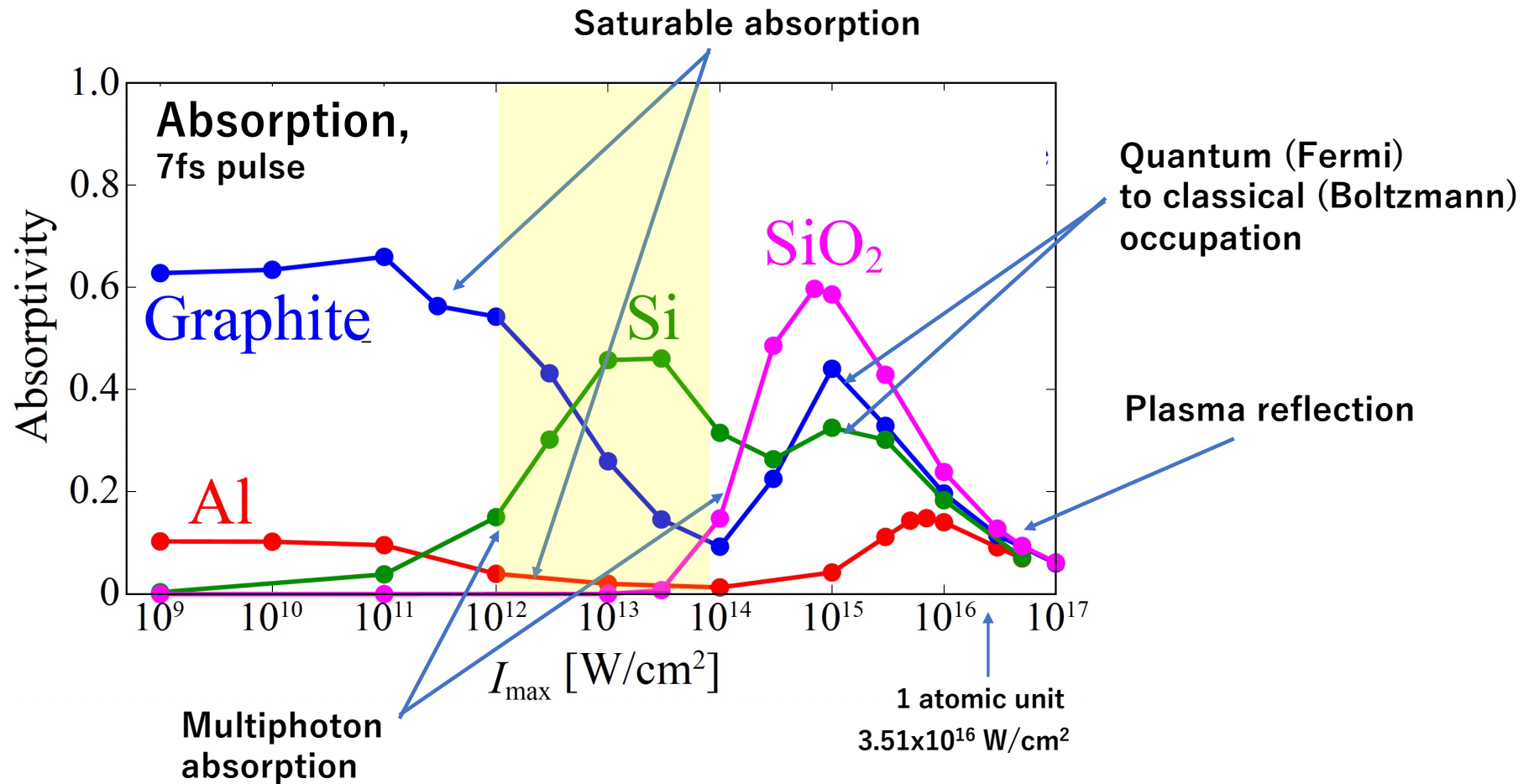
Tentative results



Oblique, multiscale Maxwell-TDDFT calculation



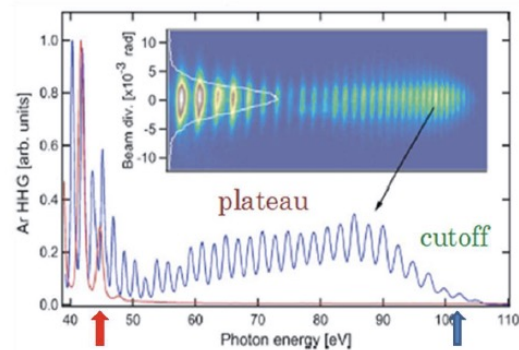
Nonlinear optical response: Mechanisms



High harmonic generation (HHG)

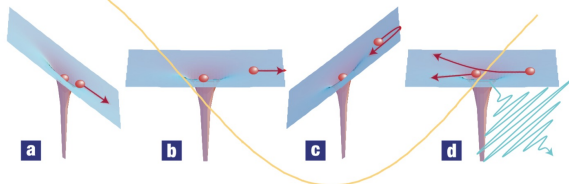
High harmonic generation from atoms

Soft X-ray from visible light



3 step model (electron rescattering)

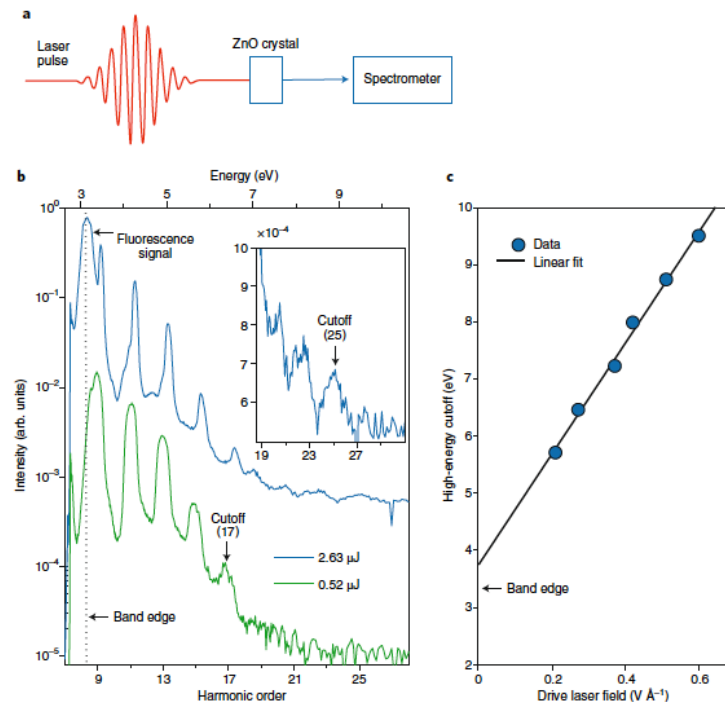
P.B. Corkum, Phys. Rev. Lett. 71, 1994 (1993)



P.B. Corkum, F. Krausz, Nature Phys. 3, 380 (2007)

High harmonic generation from solids

Compact X-ray device?



S. Ghimire et al, Nat. Phys. 7, 138 (2011)

S. Ghimire, D.A. Reis, Nature Physics 15, 10 (2019)

Macroscopic (multi-scale) Maxwell-TDDFT: pulsed light on 1 μm Si film

Change of electron density
from ground state

$$\Delta n(\mathbf{r}, t) = n(\mathbf{r}, t) - n_{GS}(\mathbf{r})$$

Front

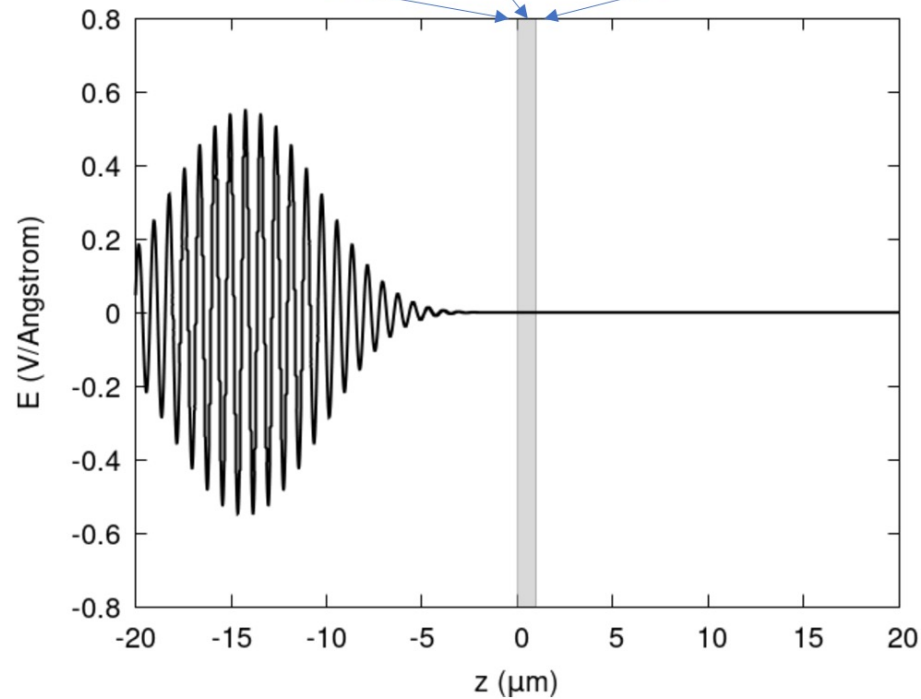
Middle

Back

~200 grid points
for 1 μm film

Thin film
Silicon, 1 μm thick

Laser pulse
800nm (1.55eV=below gap)
 $4 \times 10^{12} \text{W}/\text{cm}^2$

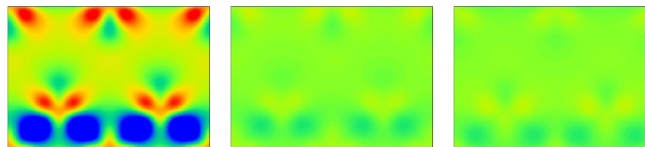


High harmonic components in transmission/reflection waves

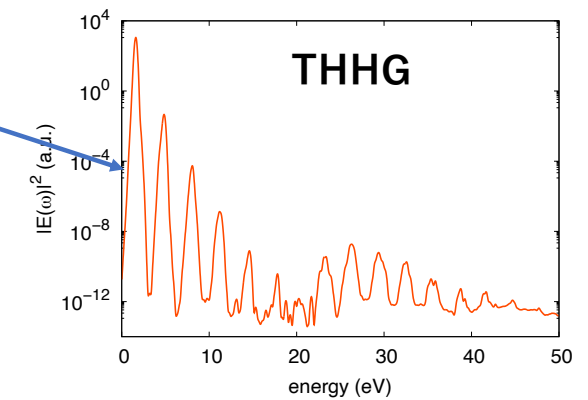
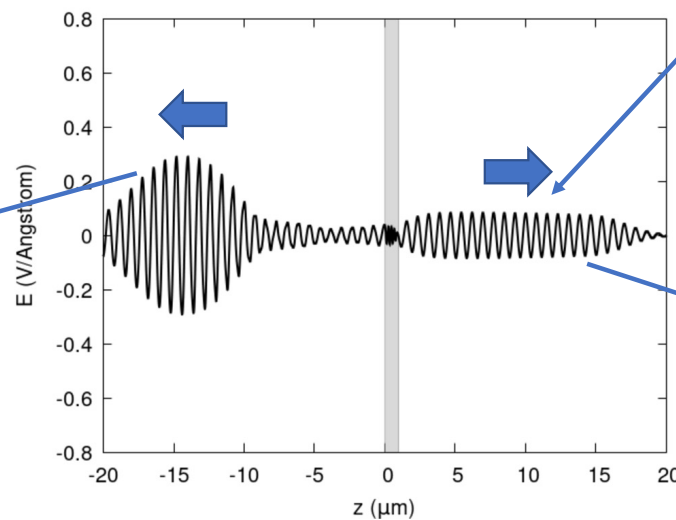
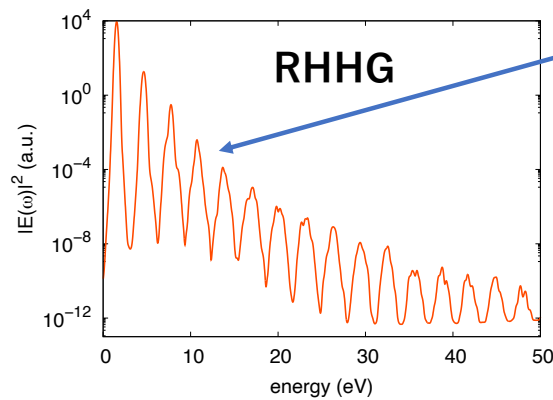
S. Yamada et.al, Phys. Rev. B107, 035132 (2023)

Thin film
Silicon, 1 μm thick

Laser pulse
800nm (1.55eV=below gap)
 $4 \times 10^{12} \text{W}/\text{cm}^2$



Flat envelope:
high field part was consumed
for electronic excitation.

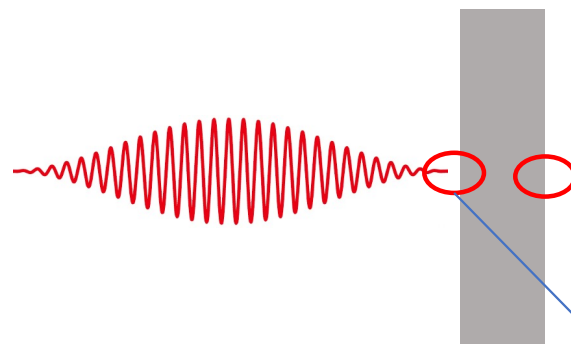


Where is HHG produced?



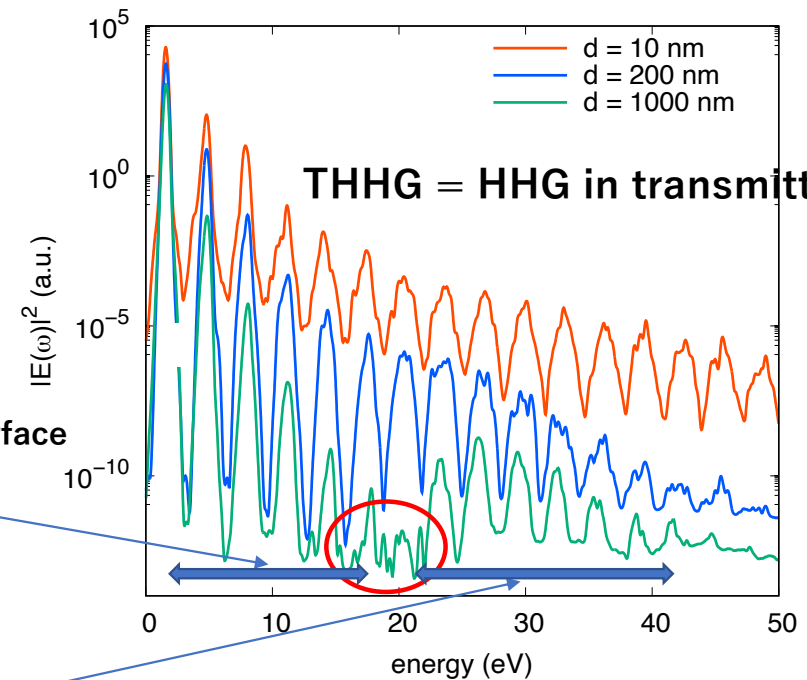
Front or back surfaces

S. Yamada et.al, PRB107, 035132 (2023)



Back surface
< 20eV

> 20eV, front surface



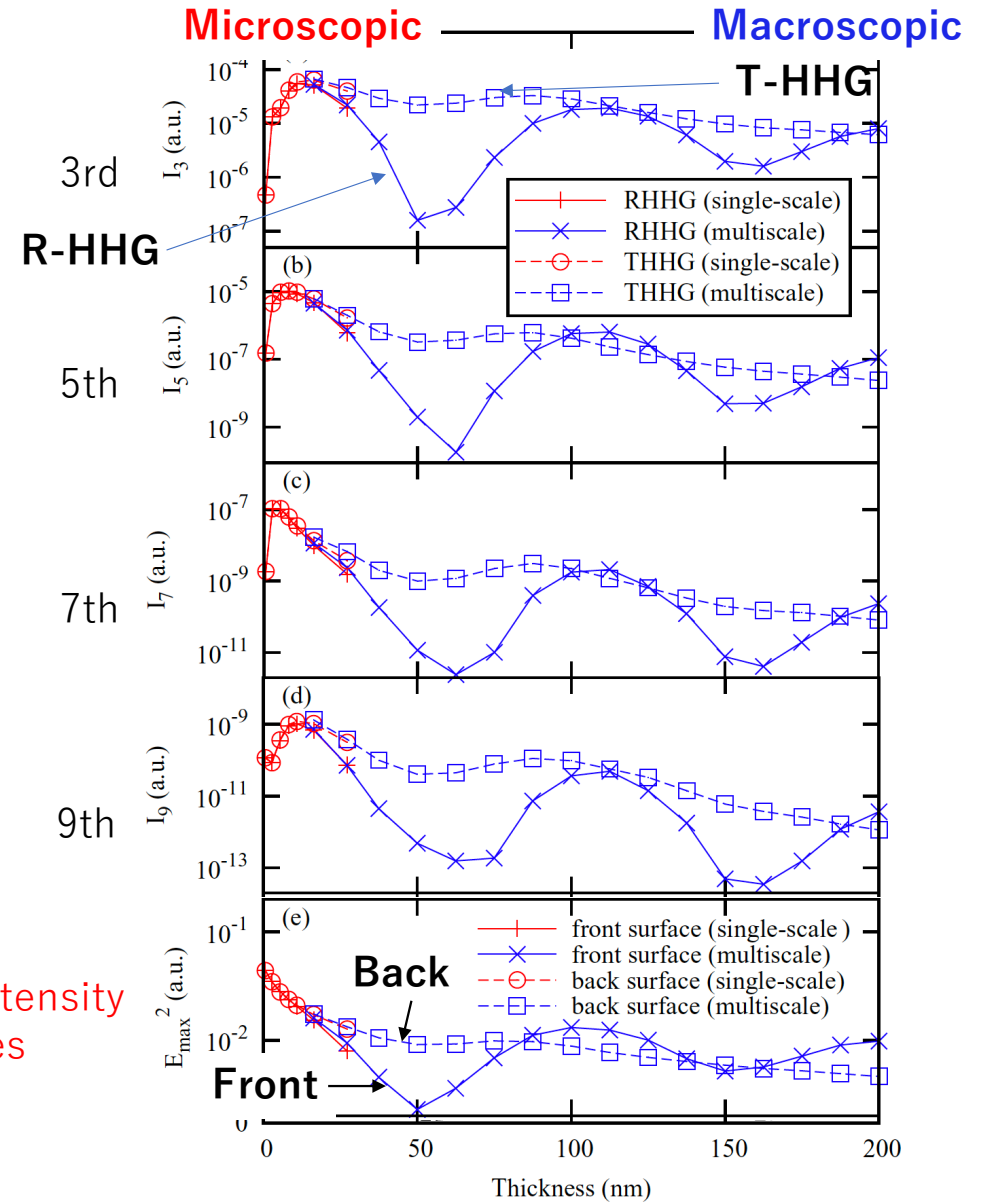
What is the most efficient thickness to produce strong HHG?



5~20nm

S. Yamada, K. Yabana, Phys. Rev. B103, 155426 (2021)

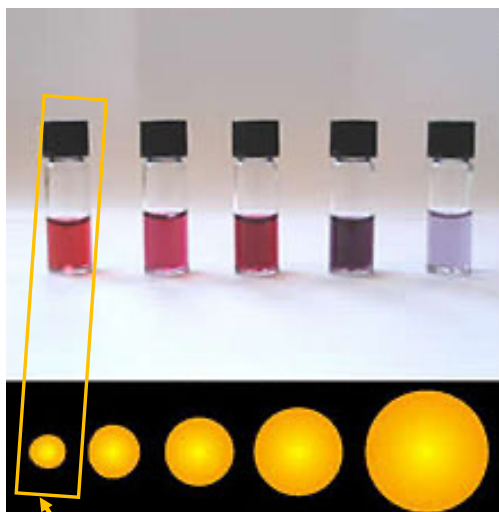
Electric field intensity
at surfaces



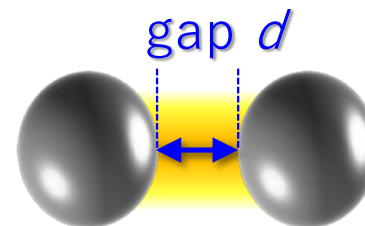
Nano-plasmonics and nonlocality

Color change of Au nano-particles

Electron spill-out at the surface
due to quantum effect



Optical absorption of nano-dimer



J.A. Scholl et.al,
Nano Lett. 13, 564 (2013)

Quantum tunneling between nano-particles affects response

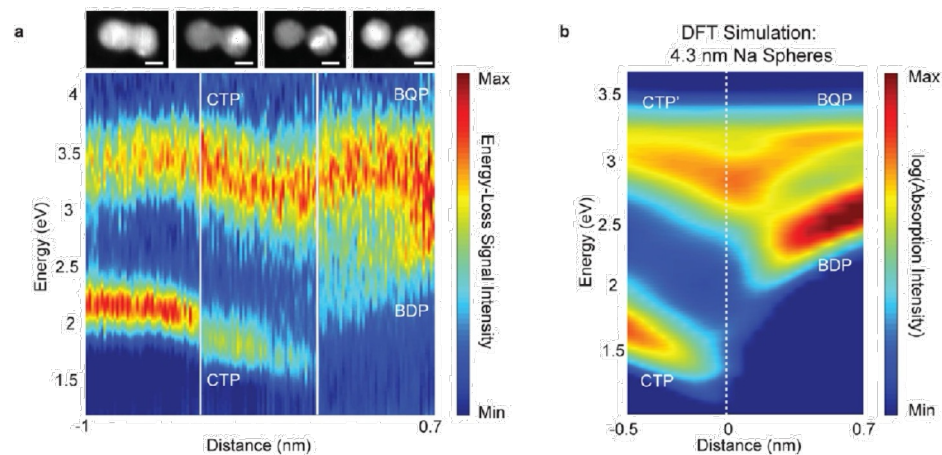
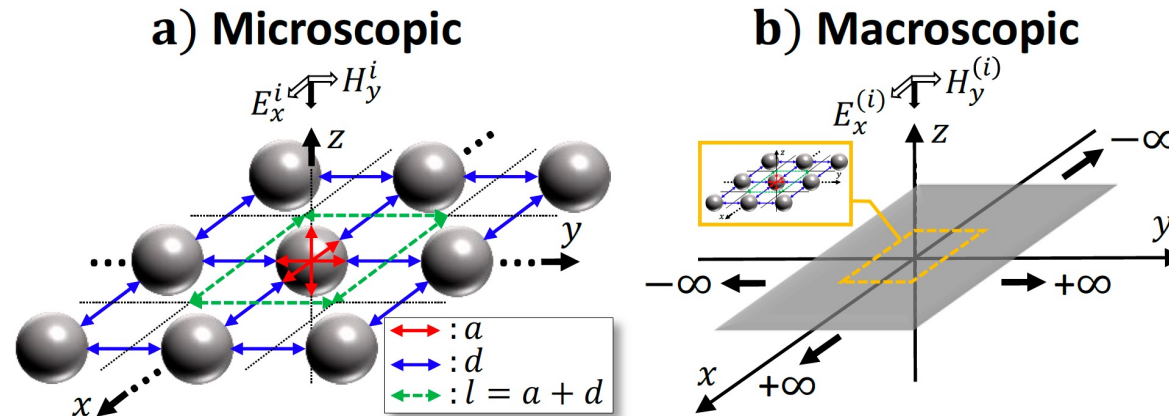


Figure 4. Continuous EELS collection to observe quantum tunneling effects at small gap sizes for silver spheres and theoretical comparison with sodium spheres. (a) A STEM-EELS probe enables particle motion during EEL spectra collection of a 9-nm-diameter silver homodimer. STEM images collected at the beginning and end of each scan (bounded by solid vertical lines) indicate the separation distances (+0.7, < 0.27, -0.3, and -1.0 nm). (b) DFT simulation of the plasmonic response of 4.3-nm-diameter sodium spheres in vacuum from recent work,¹³ with particle separation between +0.7 and -0.5 nm. The spectra from both experiment and theory exhibit a diminished BDP resonance peak at separations of only a few angstroms, indicating quantum tunneling. The charge transfer mode appears after particle contact. Image scale bars equal 5 nm.

$$\omega_M^2 = \frac{4\pi n e^2}{3m}$$

Optical response of plasmonic meta-surface with sub-nm gap

T. Takeuchi, M. Noda, K. Yabana, ACS Photonics 6, 2517 (2019).
T. Takeuchi, K. Yabana, Scientific Reports 10, 21270 (2020).



Maxwell eq. for light propagation in 2D approx.

$$\frac{1}{c^2} \frac{\partial^2}{\partial t^2} A(z, t) - \frac{\partial^2}{\partial z^2} A(z, t) = \frac{4\pi}{c} I(z, t) \quad I(z, t) = \delta(z) \tilde{I}(t)$$

TDDFT for electronic motion in jellium approx.

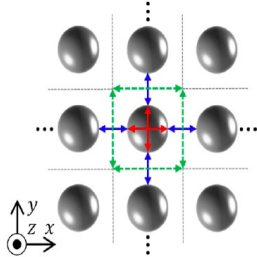
$$i \frac{\partial u_{n\mathbf{k}}(\mathbf{r}, t)}{\partial t} = \left[\frac{1}{2} \left(-i\nabla + \mathbf{k} + \frac{1}{c} \mathbf{A}(t) \right)^2 - \phi(\mathbf{r}, t) + V_{\text{XC}}(\mathbf{r}, t) \right] u_{n\mathbf{k}}(\mathbf{r}, t)$$

Optical response of plasmonic meta-surface with sub-nm gap

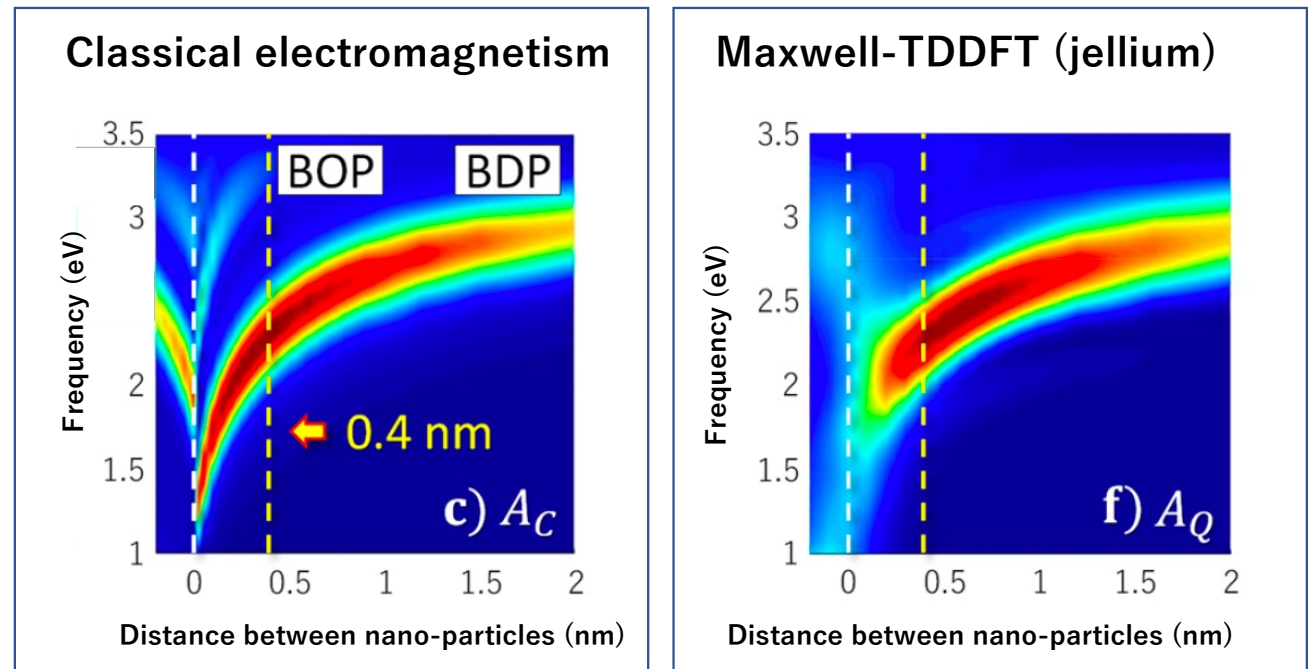


Takashi Takeuchi
RIKEN (former affiliation)

Nano-particle:
3nm radius, 398 electrons

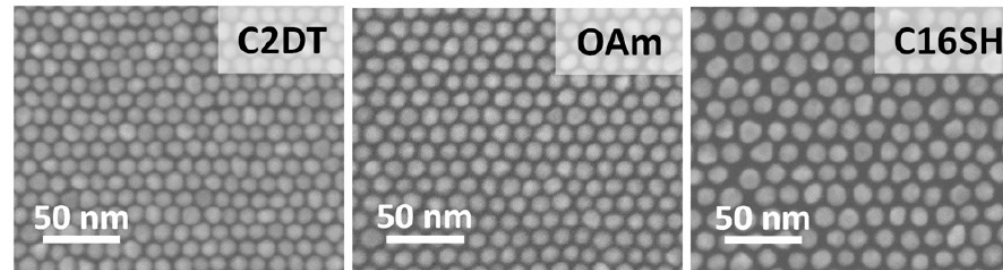


Linear absorption

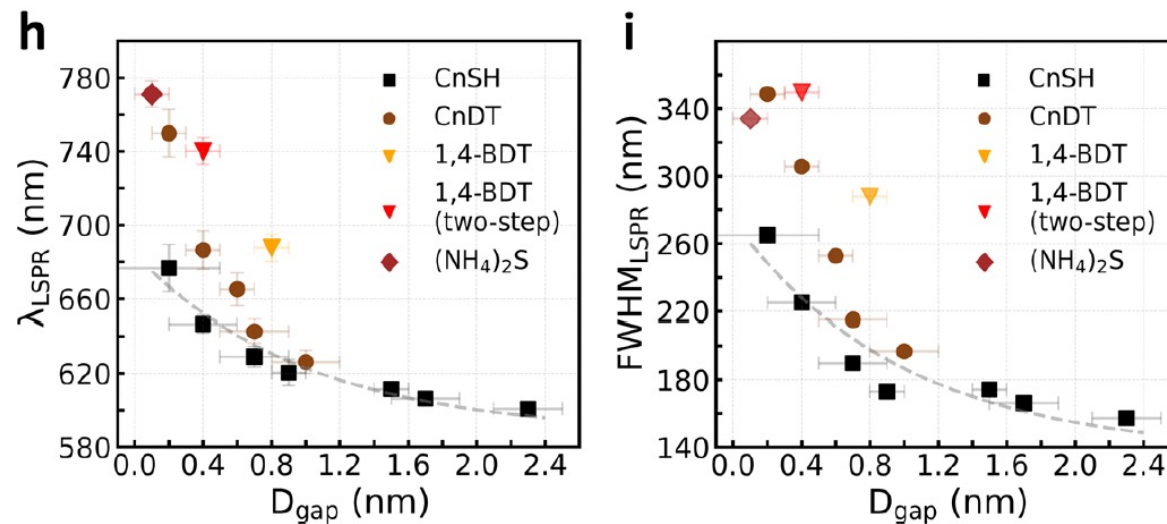


Quantum effect:
Plasmon becomes diffuse
as two particles come close ($<0.2\text{nm}$)

Recent experimental measurement (B. Lu et.al, ACS Nano 17, 12774 (2023).)

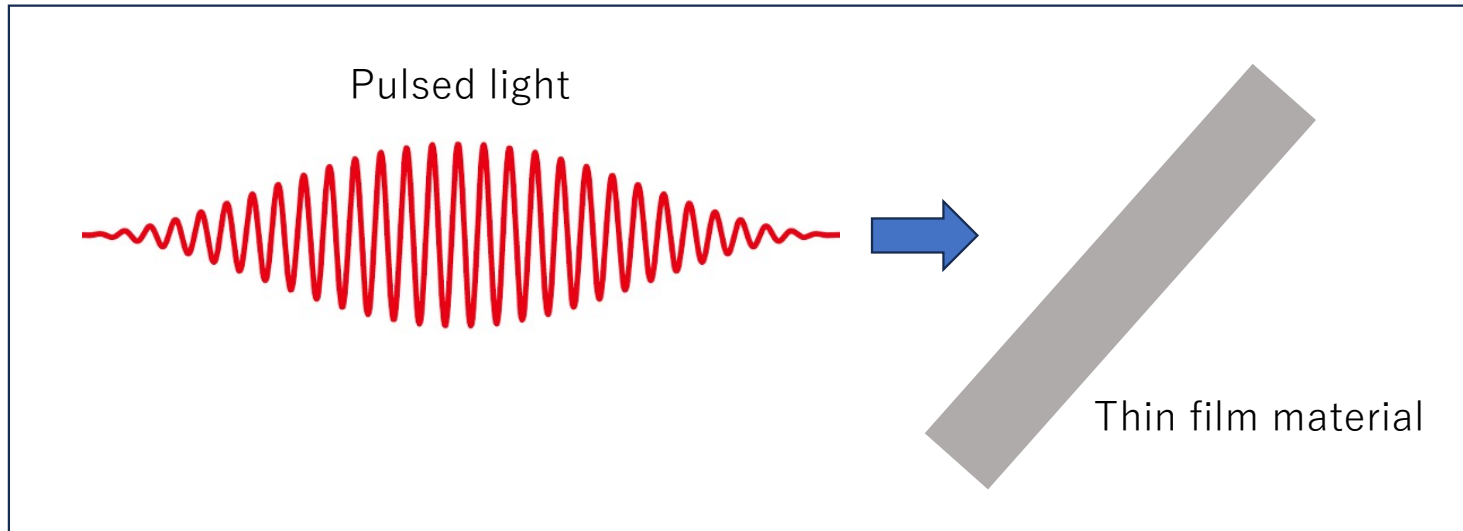


Meta-surface of Au nanoparticles (nano-particle distance as small as 0.1nm)



Strong red-shift of absorption as the gap distance decreases.

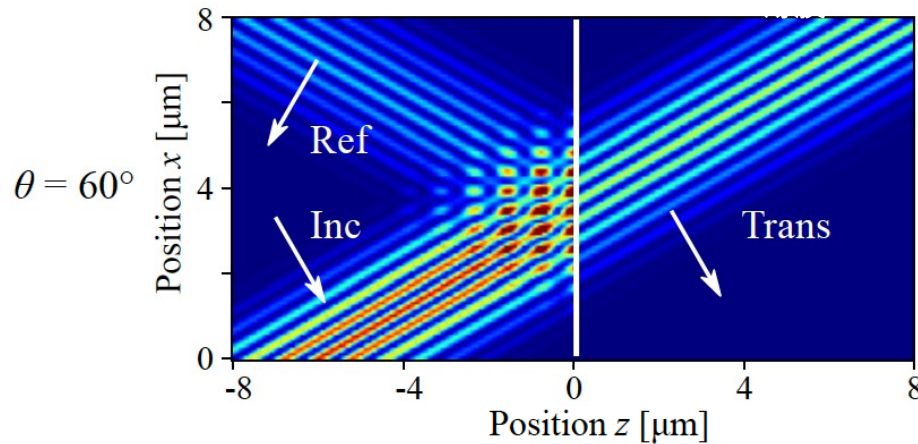
An irradiation of a thin material by a pulsed light at oblique incidence



- **Weak pulse case :**
macroscopic electromagnetism
- **Strong pulse case :**
macroscopic electromagnetism + TDDFT for electron dynamics

Multiscale Maxwell-TDDFT calculation at oblique incidence

M. Uemoto, K. Yabana, Opt. Exp. 30, 23664 (2022), K. Yabana et.al, in preparation



Translational symmetry
involving time and space

$$A(\mathbf{R}, t) = a \left(Z, t - \frac{X \sin \theta}{c} \right)$$

$$J(\mathbf{R}, t) = j \left(Z, t - \frac{X \sin \theta}{c} \right)$$

functions of z and t only

There appears no dangerous term like $(d/dz)p_z$

$$\nabla \times \mathbf{B} = \frac{4\pi}{c} \mathbf{J} + \frac{1}{c} \frac{\partial}{\partial t} \mathbf{E},$$

$$\nabla \times \mathbf{E} + \frac{1}{c} \frac{\partial}{\partial t} \mathbf{B} = 0,$$



s-polarization

$$\frac{\cos^2 \theta}{c} \frac{\partial}{\partial t} e_y(z, t) = \frac{\partial}{\partial z} b_x(z, t) - \frac{4\pi}{c} j_y(z, t)$$

$$\frac{1}{c} \frac{\partial}{\partial t} b_x(z, t) = \frac{\partial}{\partial z} e_y(z, t)$$

p-polarization

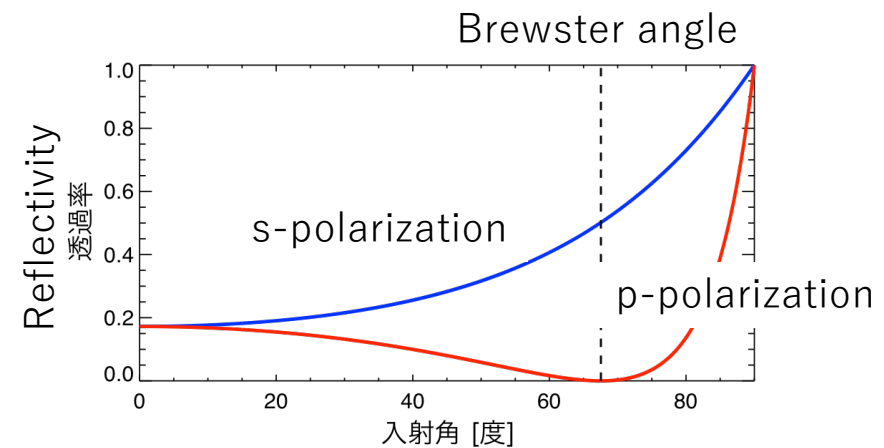
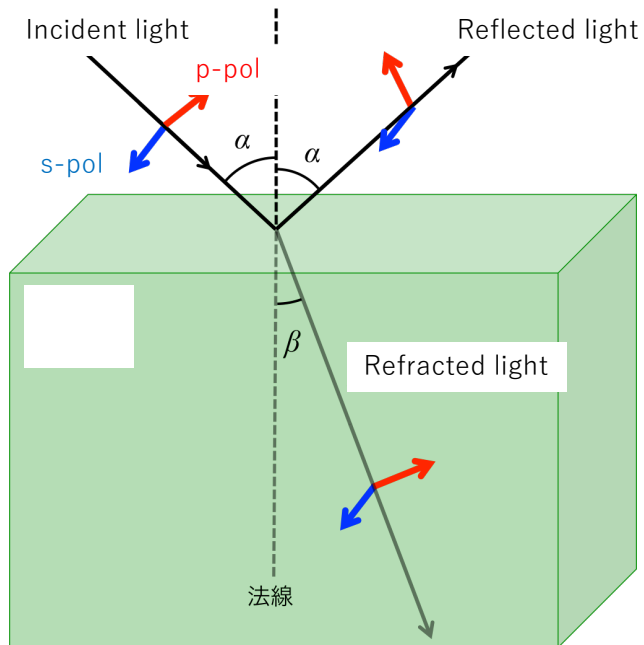
$$\frac{1}{c} \frac{\partial}{\partial t} e_x(z, t) = -\frac{\partial}{\partial z} b_y(z, t) - \frac{4\pi}{c} j_x(z, t)$$

$$\frac{\cos^2 \theta}{c} \frac{\partial}{\partial t} b_y(z, t) = -\frac{\partial}{\partial z} e_x(z, t) + \frac{4\pi}{c} \sin \theta j_z(z, t)$$

Oblique incidence can be calculated with the same computational cost as normal incidence.

Oblique-incident light propagation: linear optics

s- and p-polarizations

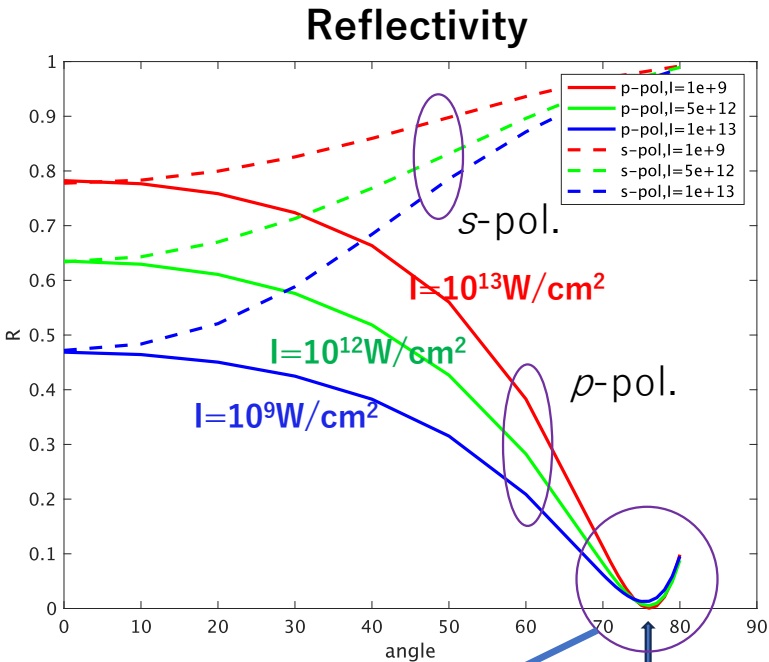
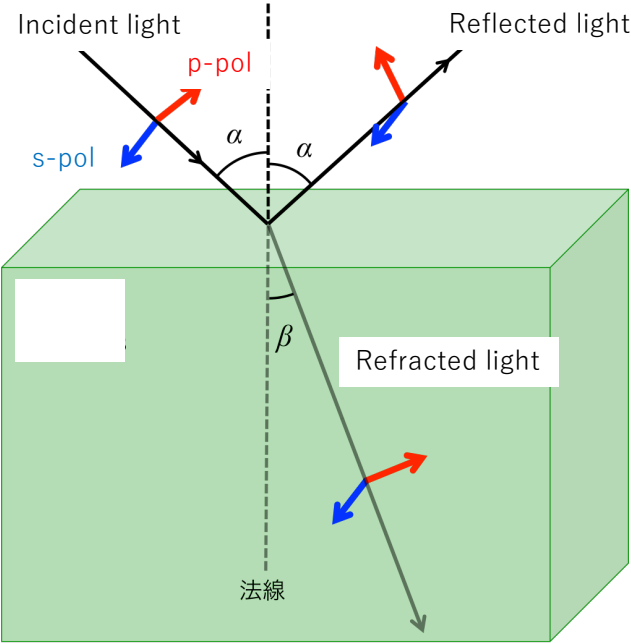


For p-polarization, zero-reflection (Brewster) angle appears.

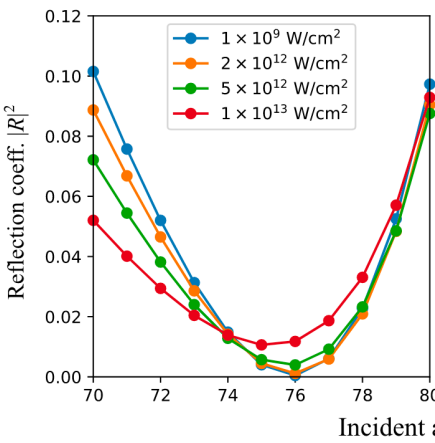
Reflectivity for strong field : Si thin film (50nm)

Brewster's angle appears robustly against intensity

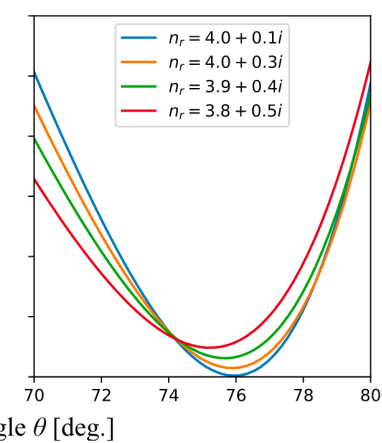
s- and p-polarizations



(a) Oblique Maxwell+TDDFT



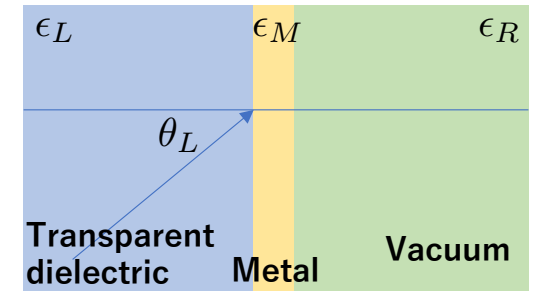
(b) Analytical model



Nonlinearity described by the change of index of refraction

Surface Plasmon Polariton in linear electromagnetism

SPP exists at the M-R interface when evanescent field appears in R region.
Incident pulse couples when the momentum matching is satisfied.



$$R = \left| \frac{A^r}{A^i} \right|^2$$

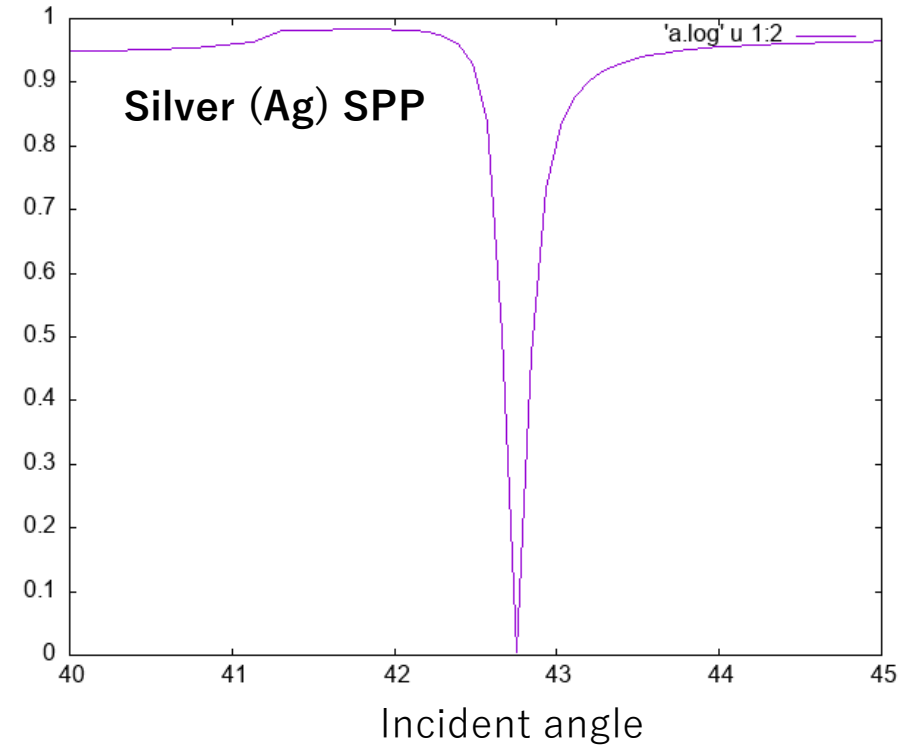
$$\frac{A^r}{A^i} = -\frac{r_{12} - r_{23}e^{2ik_M d}}{1 - r_{12}r_{23}e^{2ik_M d}}$$

$$r_{12} = \frac{f_{L,-}}{f_{L,+}}, \quad r_{23} = \frac{f_{R,-}}{f_{R,+}}, \quad k_M = \frac{\omega}{c} \sqrt{\epsilon_M - n_L^2 \sin^2 \theta_L}$$

$$f_{(R,L),\pm} = n_{(R,L)} \left\{ \frac{\sqrt{\epsilon_{(R,L)} - \epsilon_L \sin^2 \theta_L}}{\epsilon_{(R,L)}} \pm \frac{\sqrt{\epsilon_M - \epsilon_L \sin^2 \theta_L}}{\epsilon_M} \right\}$$

$$\sqrt{\epsilon_R - \epsilon_L \sin^2 \theta_L} \rightarrow i\sqrt{\epsilon_L \sin^2 \theta_L - \epsilon_R}$$

$$\epsilon_L = 2.3, \epsilon_R = 1.0, \epsilon_M = -18.23 + 0.482i, d = 1000 \text{ au} = 52.9 \text{ \AA}.$$

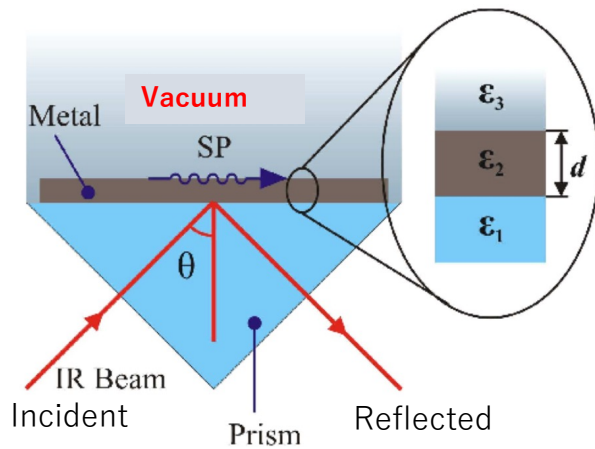


Surface Plasmon Polariton : Aluminum thin film (10nm)

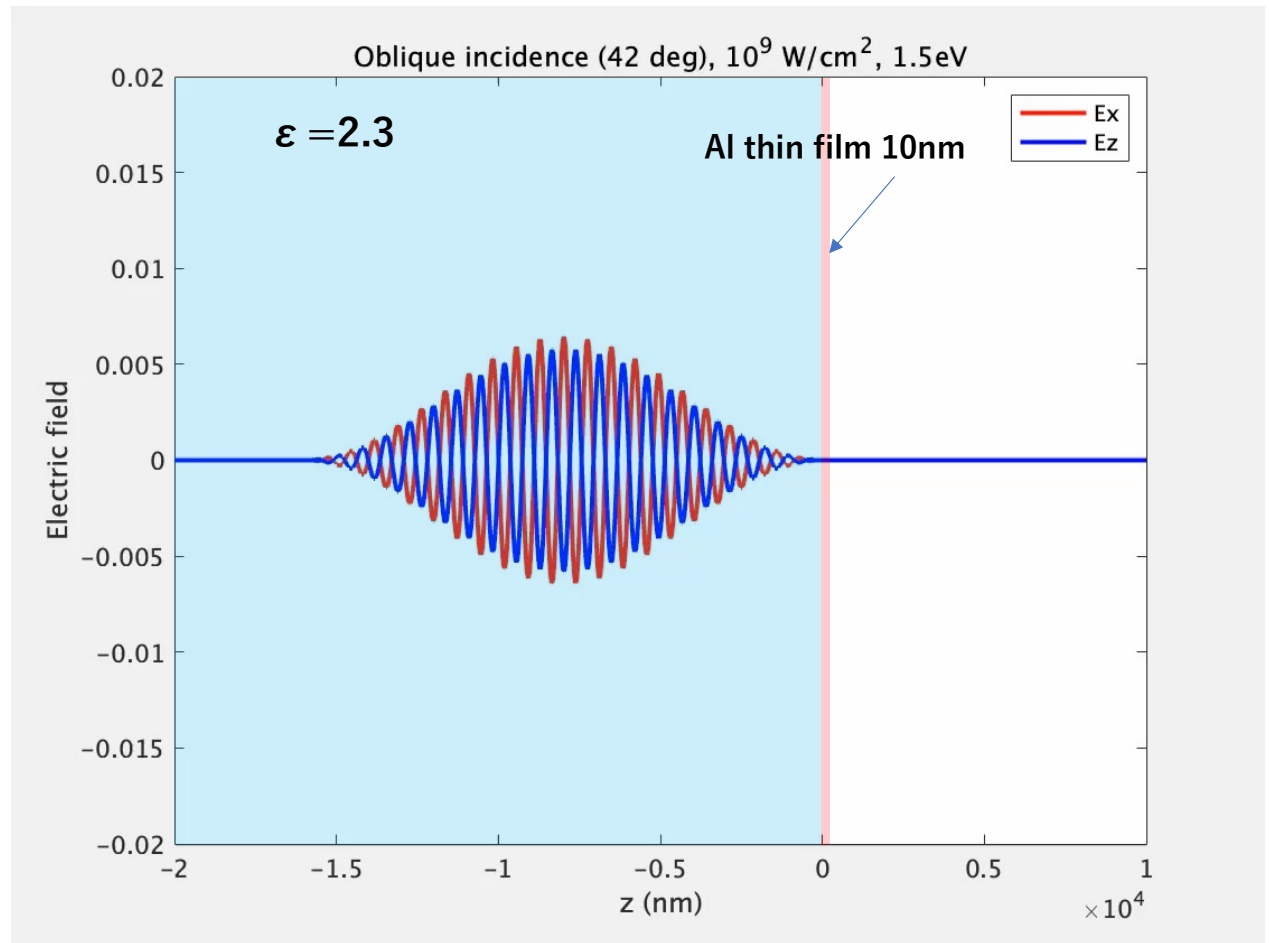
Multiscale Maxwell-TDDFT calculation at oblique incidence

Weak pulse: $I=10^9 \text{ W/cm}^2$, $hw=1.5\text{eV}$, 42 deg., *p*-polarization

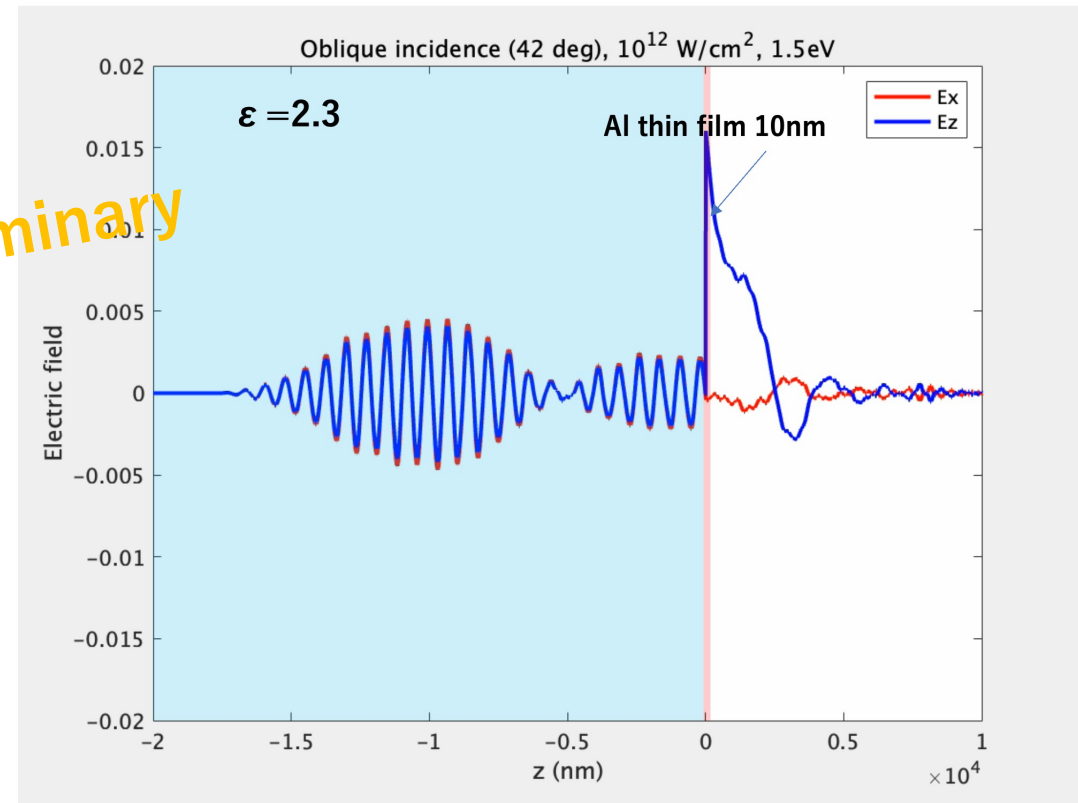
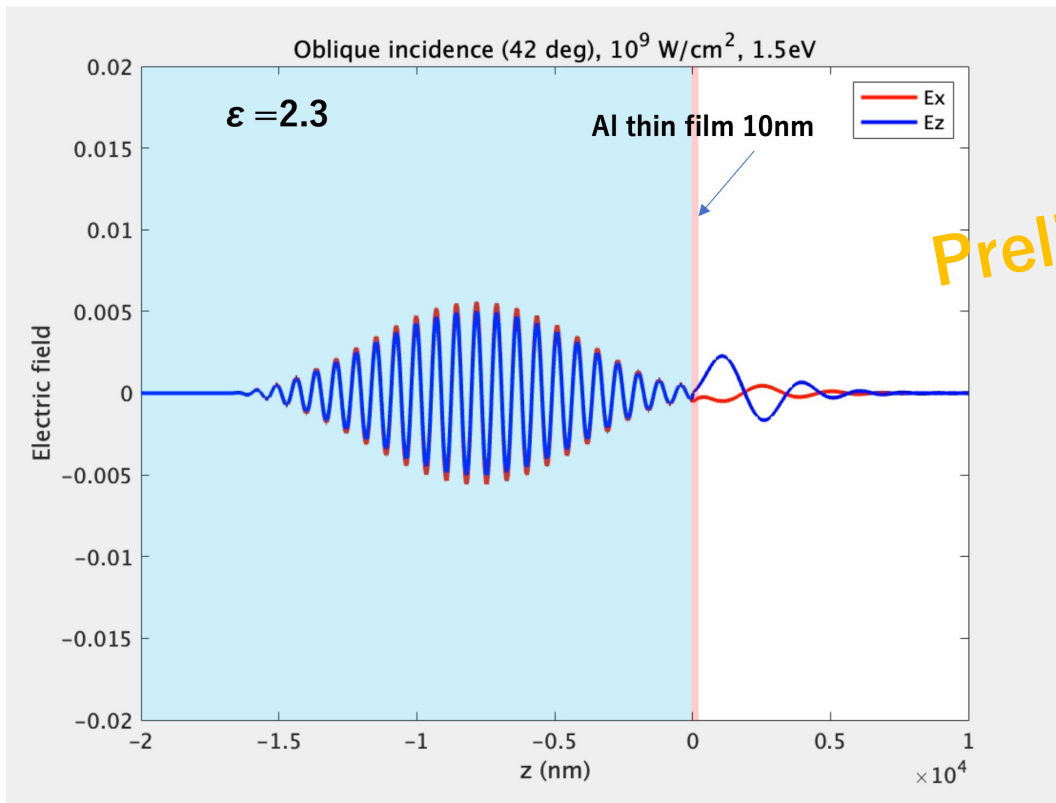
Kretschmann geometry



Surface plasmon mode appears when evanescent field appears in the vacuum region.



Multiscale Maxwell-TDDFT calculation at oblique incidence

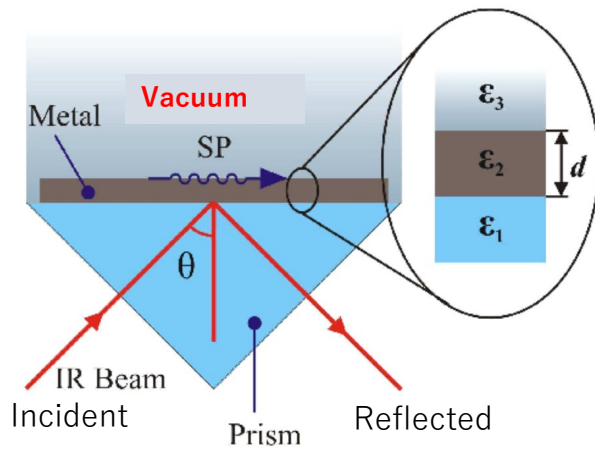


Preliminary

Strong nonlinearity! Only strong pulse shows coupling with surface plasmon.

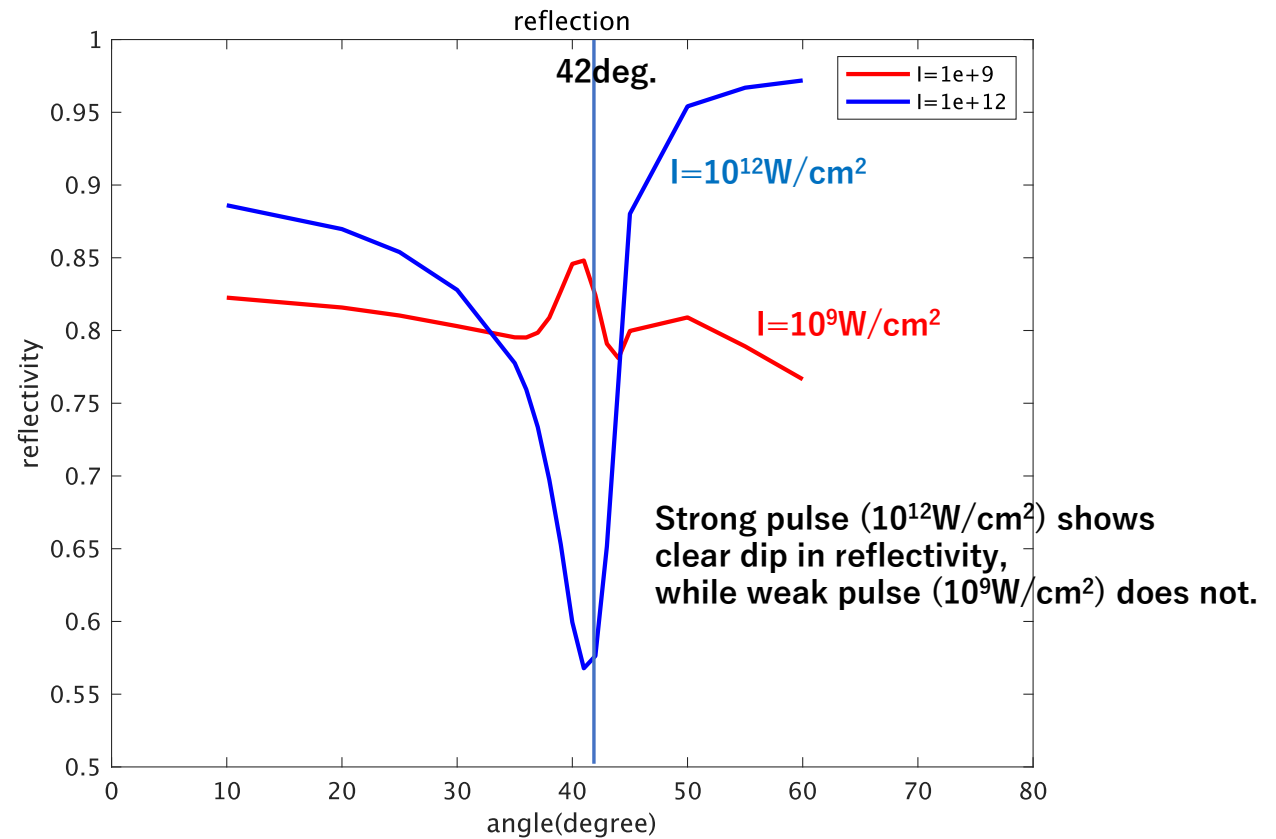
Multiscale Maxwell-TDDFT calculation at oblique incidence

Kretschmann geometry



Surface plasmon mode appears when evanescent field appears in the vacuum region.

Angle dependence of reflectivity



Summary

In current frontier of optics characterized by ultrafast, nonlinear, and nonlocal, traditional EM or QM approaches are not sufficient.

We develop first-principles electromagnetic analysis, combining EM and QM (Real-time TDDFT)

There are two connection methods: macroscopic (multiscale) and microscopic (single-scale)

Applications include high harmonic generation, laser processing, plasmonic meta-surface etc.

All calculations use



<https://salmon-tddft.jp>

Scalable **A**b initio **L**ight – **M**atter simulator for **O**ptics and **N**anoscience

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Q-LEAP

Supercomputers

